Advanced Atmospheric Water Vapor Dial Detection System

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ADVANCED ATMOSPHERIC WATER VAPOR

DIAL DETECTION SYSTEM

by

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B.Sc. June 1991 Alexandria University
M.Sc. August 1995 Alexandria University

A Thesis Submitted to the Faculty of
Old Dominion University in Partial Fulfillment of the
Requirements for the Degree of

DOCTOR OF PHILOSOPHY

ELECTRICAL ENGINEERING

OLD DOMINION UNIVERSITY
August 2000

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ABSTRACT

ADVANCED ATMOSPHERIC WATER VAPOR
DIAL DETECTION SYSTEM

Tamer Refaat
Old Dominion University, 2000
Director: Dr. Hani E. Elsyed-Ali

Measurement of atmospheric water vapor is very important for understanding the Earth’s climate and water cycle. The remote sensing Differential Absorption Lidar (DIAL) technique is a powerful method to perform such measurement from aircraft and space. This thesis describes a new advanced detection system, which incorporates major improvements regarding sensitivity and size. These improvements include a low noise advanced avalanche photodiode detector, a custom analog circuit, a 14-bit digitizer, a microcontroller for on board averaging and finally a fast computer interface.

This thesis describes the design and validation of this new water vapor DIAL detection system which was integrated onto a small Printed Circuit Board (PCB) with minimal weight and power consumption. Comparing its measurements to an existing DIAL system for aerosol and water vapor profiling validated the detection system.

Co-Director of Advisory Committee: Dr. Russell J. DeYoung
Spiritual Support builds The Will.

THIS THESIS IS DEDICATED TO MY MOTHER AND BROTHER.
ACKNOWLEDGMENTS

I would like to express my sincere gratitude to my advisor, Prof. Dr. Hani Elsayed-Ali, for his invaluable guidance and encouragement throughout the work done for this thesis.

It has been a great pleasure to work with Dr. Russell J. DeYoung. He inspired me to do this work, and he kept it going with dedication and enthusiasm. I cannot find enough words to thank him for his continuous guidance, support and encouragement. I would have not gone so far without him. It has been an honor to work at NASA Langley Research Center under his supervision.

I would like to thank Dr. Gary E. Halama for his contribution to this thesis. Dr. Halama supervised the experimental characterization of the detectors, which added to my experience. Also I would like to thank William S. Luck, Jr. Mr. Luck introduced me to the lidar detection system design and generously provided me the use of his laboratory at NASA Langley Research Center, Aerospace Electronic System Division.

I would like to thank the operating personnel of the NASA Langley Research Center airborne DIAL system, Atmospheric Science Division, and the personnel at Science and Engineering Services Inc., for their help in the validation process of the detection system.

Last, but not least, I would like to thank all those helped in one way or another in the work done for this thesis. In addition, I like to thank the members of my defense committee, Dr. Linda Vahala, Dr. W. Gray and Dr. Sebastian Kuhn, for their suggestions, comments and beneficial discussions.
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CHAPTER I

INTRODUCTION

1.1. Atmospheric water vapor

Water vapor is an important molecular species which is primarily located in the Earth’s troposphere (part of the atmosphere extending from the surface of the Earth up to an altitude of about 18 km). Although the distribution of atmospheric water vapor is highly variable in both time and location, its measurement is very important for understanding the Earth’s water cycle, the greenhouse effect and weather phenomena.\textsuperscript{1,2}

The water cycle provides a direct way for interactions among Earth’s global systems, namely, the atmosphere, hydrosphere, cryosphere, lithosphere and biosphere. Water is considered the main media for energy transfer between most of these systems. Although the amount of atmospheric water vapor represents only a small percent of the Earth’s water reservoir, it is very dynamic and its latent heat for transformation is considered the main energy source that maintains the atmospheric circulation.\textsuperscript{1,2}

Water vapor and clouds affect the incident solar radiation by reflecting solar radiation back to space and also absorbing some of this energy within the atmosphere. This substantially moderates the Earth’s climate. On the other hand, water vapor and clouds affect infrared radiation released by the Earth’s surface. Some of this radiation is reflected back to the surface and some is absorbed and re-emitted at a lower temperature which contributes to the global warming problem or greenhouse effect.\textsuperscript{2}

Journal model used for this thesis is *Optical Engineering.*
Water vapor has a direct role in most weather phenomena and natural disasters such as hurricanes. It was found that the latent heat of water vapor is the main energy source for hurricanes. The measurement of water vapor flow into a hurricane associated with other observations aids in estimating the hurricane strength and direction.\textsuperscript{3,4}

Water vapor measurements can be obtained by balloon radio-sondes but a more effective method is the laser remote sensing technique onboard an aircraft or satellite. Such systems have the advantage of obtaining two-dimensional water vapor profiles with high accuracy.\textsuperscript{5,6}

1.2. Water vapor measurements using lidar

Light detection and ranging (lidar) is a remote sensing technique which is currently used for atmospheric water vapor measurements.\textsuperscript{5,6} At NASA Langley Research Center, the lidar atmospheric sensing experiment (LASE) uses the differential absorption lidar (DIAL) technique to measure water vapor profiles using the ER-2, DC-8 or P3-B aircraft.\textsuperscript{6-13} LASE consists of three main systems, the DIAL laser transmitter, the receiver and the control and data acquisition system.\textsuperscript{7}

In a typical water vapor DIAL system two laser pulses separated by a time interval are transmitted into the atmosphere. The wavelength of the first pulse is tuned to the peak of a water vapor absorption line and is called the on-line wavelength, while the second wavelength is adjusted to a water vapor spectral region with no absorption and is called the off-line wavelength. The two wavelengths are selected close to each other; therefore, the scattering by other atmospheric molecules and particles is the same for both on and off laser wavelengths and the difference in the on- and off-line return signals will be

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entirely due to the absorption by water vapor molecules. Thus, the ratio of the backscattered signals at the two wavelengths can be used to calculate the water vapor concentration profile as a function of range.\textsuperscript{14-16}

This principle was applied to the LASE instrument which is shown in the block diagram of Figure 1.1. LASE is an instrument that detects water vapor using the 815-nm water vapor absorption line. LASE measurements were found to have an accuracy better than 6\% or 0.01 g/kg, whichever is greater across the entire troposphere.\textsuperscript{7-11}

![LASE system block diagram](image)

Figure 1.1 LASE system block diagram.\textsuperscript{7}

The LASE transmitter was designed to generate two laser pulses of 30 ns duration separated by 400 $\mu$s at a frequency of 5 Hz with a pulse energy output of 150 mJ. A Ti:Sapphire (Ti:Al\textsubscript{2}O\textsubscript{3}) power oscillator was constructed using a Nd:YAG laser as the pump source. Narrow linewidth and wavelength tuning of the Ti:Al\textsubscript{2}O\textsubscript{3} laser is achieved
by a continuous wave 100-mW single mode diode laser performing as an injection seed source. This injected seeding allows control of the spectral linewidth to within 1 pm and provides wavelength tuning stability to ±0.25 pm. The diode laser wavelength is locked onto the selected water absorption line and tuned by passing a fraction of its frequency modulated light through a reference cell filled with water vapor and detecting the cell transmission. The tunable diode laser seeds the pulsed laser alternately between the online wavelength located at the center of the water vapor absorption line and the off-line wavelength typically located 20 to 80 pm away from the online wavelength.7

The LASE receiver has a Cassegrainian telescope with a 40-cm diameter collecting area. The received light is split into two channels. The two data channels use silicon avalanche photodiodes (APDs) in order to increase the dynamic range. The first low-gain channel uses 12% of the collected light for measuring strong return signals while the second high gain APD channel uses 88% for low signal level detection. The APD detectors for both channels where manufactured by EG&G (model C30955E) with a 1.5-mm diameter active area.7

The APD detector output signal is applied to a trans-impedance amplifier stage which limits the signal bandwidth to 2.5 MHz. A 1.5 MHz low-pass filter is used to set the signal bandwidth, and then the signals are applied to 12-bit, 10-MHz digitizers. Both the amplifier and the digitizer stages are mounted in a CAMAC (Computer Automated Measurements and Control) crate, which communicates with an onboard computer for data recording. The whole system is synchronized by a time-based trigger signal.7,9

While LASE has performed well, there are several improvements in the detection system that could be made to reduce system mass and improve performance. Eliminating
the CAMAC crate would reduce the system mass substantially, and using advanced super-low-ionization-coefficient (SLIK) APD technology could reduce the system noise, thus improving measurement range. These improvements are the subject of this research dissertation.

1.3. Research objectives

In order to obtain global atmospheric water vapor profile measurements, DIAL systems such as LASE should be incorporated in aircraft or satellite-based systems. This requires the development of DIAL systems with reduced size, mass and power consumption as well as increased measurement capabilities. This will require higher energy laser systems, but a major part of this development also must be applied to the detection system.

The research objective of this dissertation was to design, build and test an advanced, compact, low-mass water vapor DIAL detection system that is used to increase the performance of the LASE instrument and also serve as a receiver prototype for future space missions. This new detection system increase the signal-to-noise ratio (SNR) by a factor of 10 compared to the current LASE receiver. Also it was integrated into a small size suitable for mounting directly on the receiver telescope. The system consists of an advanced low noise APD, an analog circuit, a 14-bit digitizer and a digital interface to a personal computer all on one small electronic card. These goals were achieved using state-of-the-art electronic components and a newly evaluated very low noise APD detector and constructing a 10-MHz waveform digitizer which is placed as close as possible to this detector on the same card.\textsuperscript{17-20} The APD is a very critical device in such
systems, since it directly affects the water vapor measurement accuracy and range. Therefore, the selection of this device was obtained after modeling its performance and characterizing a group of APDs from different manufacturers.\textsuperscript{21,22}

The design of the new DIAL detection system, the subject of this thesis, is shown schematically in Figure 1.2. The design allows the placement of both analog and digital circuits on one small-size light weight printed circuit board which includes detection and digitization sections. This scheme has the advantage of transmitting digital data for storage and analysis by a personal computer; therefore, analog signals do not have to be transmitted for long distances which reduces the system noise pick up.\textsuperscript{18-20}

![Figure 1.2 Schematic of the new DIAL receiver system.](image)

The system design was optimized for water vapor absorption lines near 820 and 940 nm. In the receiver system, an existing telescope was used to collect and focus the lidar return signal onto the APD detector sensitive area. The APD output signal was then applied to the analog circuit for signal conditioning which includes signal saturation

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protection, amplification, and filtering. In addition, this stage provides the APD with a stable bias voltage and temperature control.\textsuperscript{18-20}

The analog signal is then applied to the digital circuit to be digitized and then processed and temporarily stored. This circuit is compatible with a parallel input/output computer interface for final data storage and display, and provides monitoring of the detector high voltage bias and temperature. The whole system card is supplied with $\pm 5$ V and $\pm 12$ V power and a 10-MHz clock signal for digitization. This new detection system increases the accuracy and range of water vapor measurements over the current LASE receiver system.\textsuperscript{18-20}

The new detection system has the advantage of eliminating the CAMAC crate, thus reducing the mass and power consumption compared to the LASE instrument. A prototype receiver system was built, tested and evaluated. The prototype receiver system was used to measure relative aerosol profiles and actual atmospheric water vapor profiles to validate its performance.\textsuperscript{23}
CHAPTER II

AVALANCHE PHOTODIODE: THEORY AND MODEL

APDs are solid state quantum detectors suitable for low light detection in the visible and near infrared regions. These devices are commercially available from many manufacturers and are fabricated using different solid state structures. In this chapter, the basic APD structures will be described in order to develop a mathematical model for such devices. The model will be converted into an equivalent circuit and will be validated.

2.1. Avalanche photodiode structure and theory of operation

The basic structure of a PIN diode as well as three different structures of APDs and their electric field distribution is shown in Figure 2.1. The PIN diode shown in Figure 2.1a is a p-n junction with an intrinsic or lightly-doped layer sandwiched between the p and n layers. This structure serves to extend the width of the depletion region which increases the volume available for absorbing the incident photons. Also it reduces the junction capacitance, thereby reducing the RC time constant resulting in higher detection bandwidth. Thus, the response time of these devices is in the tens-of-pico-second range which corresponds to giga-hertz bandwidths. A disadvantage of PIN detectors is that they have no internal gain mechanism which reduces signal-to-noise ratio. The APD structure is similar to the PIN diode structure except for an additional gain mechanism within the device. This gain mechanism depends on the impact ionization process in which the photoelectric charge carriers, due to their high energy, can impact and cause ionization of lattice atoms generating more carriers resulting in the internal gain.
As shown in Figure 2.1b, the beveled-edge APD has the simplest structure among them. It consists of a p⁺-n junction with a high resistivity n layer which increases the breakdown voltage of the device into the kilovolt range. Breakdown at the edges is prevented by beveling and making the junction very deep (in the range of 50 μm). Therefore, the dead part of the p⁺ layer is usually etched away to reduce the device depth. Because the n layer is much deeper than the p⁺ layer, electrons produced there are more likely to be multiplied than holes. This reduces the dark-current noise which is mostly generated by hole current. The disadvantage, however, is that only light absorbed in the p layer leads to effective multiplication and this layer has the lowest electric field. As a result, charge accumulates slowly leading to a longer response time typically in the range of tens of nanoseconds.\(^{28}\)

The reach-through structure APD and its electric field distribution are shown in Figure 2.1c. This structure consists of an absorption region and a separate multiplication region. In the absorption region, the p⁺ layer at the active surface is followed by an intrinsic wide layer which increases the photon absorption depth. The emitted photoelectrons drift and reach a constant velocity. In the multiplication region, the p-n⁺ layers form a thin junction with a high internal field which enhances the impact ionization process.\(^{28-30}\) Recently, an enhancement of the reach-through structure known as the “super low ionization ratio κ” (SLIK) geometry has become available and is shown in Figure 2.1d.\(^{31}\) The ability of electrons and holes to “impact ionize” in order to generate additional charge carriers is characterized by the ionization coefficients \(\alpha\) and \(\beta\), for electrons and holes respectively. The ionization coefficient represents the ionization probabilities per unit length. An important parameter is the ionization ratio, \(\kappa\), given by
In APDs, it is desirable to reduce $\kappa$ as much as possible so the multiplication process is only due to electrons, since hole current leads to high dark-current noise.\textsuperscript{24} This was achieved in the SLIK structure by increasing the absorption region electric field and merging this region with the multiplication region.\textsuperscript{31} Typically, the value of $\kappa$ is in the range of 0.02 for the reach-through structure while it is 0.002 for the SLIK structure.\textsuperscript{31}

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2.2. Modeling of four layer avalanche photodiode

Large efforts were made to model the different structures of APDs, but little work has focused on developing an equivalent circuit for these devices.\textsuperscript{28,32} Chen and Liu constructed an equivalent circuit model for three layer PIN-APD and applied it to In\textsubscript{0.53}Ga\textsubscript{0.47}As-InP PIN-APD.\textsuperscript{33} This model was based on the study of the minority carrier generation, diffusion and drift through the different layers of the device, by applying both the rate and continuity equations. The drift-diffusion model was converted into an equivalent circuit. In this section the Chen-Liu model will be extended to the case of four layer APDs, such as the reach-through and SLIK structures, in order to solve for the characteristics and response and to obtain an equivalent circuit for such devices.\textsuperscript{21} This APD model is capable of simulating the transient and steady state behavior of an APD knowing its microstructure. The model simulation results were compared to a commercial reach-through silicon APD in order to validate it.\textsuperscript{21,34}

A schematic of the structure of a reach-through APD as well as the internal electric field distribution are shown in Figures 2.2a and 2.2b respectively. As discussed earlier, the field profile shown in Figure 2.2b distinguishes the two main regions within the device. The first is the absorption region which is used to absorb the incident photons to generate photo-charge carriers and drift these carriers into the second region. The second region is the multiplication region which has a relatively smaller depth with higher field. In this region, the photo-generated carriers produce additional carriers by the impact ionization process. For the sake of simplicity in this model, the electric field profile will be approximated by two step functions as shown in Figure 2.2c. The lower field value is for the absorption region that is covered by the i layer, while the higher field value is for
the multiplication region which is almost covered by the p layer. The electric field will be neglected in the outer highly-doped layers since they have relatively smaller depletion widths. Under these approximations the device currents in the p⁺-i and p-n⁺ interfaces will be due to the diffusion currents of the minority carriers form the highly doped layer, and the drift current of the generated charge carries in the internal regions.²¹

Figure 2.2 (a) Schematic diagram of a four layer APD showing light absorption through the device with (b) simulated²⁴ and (c) approximate electric field profiles.
The absorption profile along the device depth is also shown in Figure 2.2a. Considering the input optical power $P_{in}$ at a wavelength $\lambda$, the incident photon flux is given by

$$G_0 = \frac{P_{in} \lambda}{hc},$$

(2.2)

where $h$ is Planck's constant and $c$ is the speed of light in vacuum. A part of this flux will reflect back at the APD surface and the other part will penetrate the device and will be given by

$$G_1 = G_0 (1 - R),$$

(2.3)

where $R$ is the APD surface reflection coefficient. Since the electron-hole pair photogeneration rate is directly proportional to the number of absorbed photons, this rate will be given as (in $s^{-1}$) for the $p^+$, $i$, $p$ and $n^+$ layers, respectively, by

$$G_{pp} = G_1 \cdot [1 - \exp(-\alpha_{pp} W_{pp})],$$

(2.4)

$$G_i = G_1 \cdot \exp(-\alpha_{pp} W_{pp}) \cdot [1 - \exp(-\alpha_i W_i)],$$

(2.5)

$$G_p = G_1 \cdot \exp(-\alpha_{pp} W_{pp} - \alpha_i W_i) \cdot [1 - \exp(-\alpha_p W_p)],$$

(2.6)

$$G_{nn} = G_1 \cdot \exp(-\alpha_{pp} W_{pp} - \alpha_i W_i - \alpha_p W_p) \cdot [1 - \exp(-\alpha_{nn} W_{nn})],$$

(2.7)

where $\alpha_{pp}$, $\alpha_i$, $\alpha_p$ and $\alpha_{nn}$ are the absorption coefficients and $W_{pp}$, $W_i$, $W_p$ and $W_{nn}$ are the widths of the $p^+$, $i$, $p$ and $n^+$ layers, respectively.

2.2.1. Rate equations

Considering a reverse bias device, the rate of increase of the number of electrons in the $p^+$ layer (minority carriers) will be proportional to the photo-generation rate and
opposed by the recombination and diffusion. Thus the rate equations for the electrons in
the $p^+$ layer is given by
\[
\frac{dP_{p}}{dt} = G_{pp} - \frac{P_{ppe}}{\tau_{ppe}} - \frac{I_{ppe}}{q}.
\]  
\(2.8\)

Similarly for the $n^+$ layer, the rate equation of the holes (minority carriers) is given by
\[
\frac{dP_{n}}{dt} = G_{nn} - \frac{P_{nh}}{\tau_{nnh}} - \frac{I_{nnh}}{q},
\]  
\(2.9\)

where $P_{ppe}$ and $P_{nnh}$ are the number of excess electrons and holes, $\tau_{ppe}$ and $\tau_{nnh}$ are the
electron and hole life times for the $p^+$ and $n^+$ respectively, $I_{ppe}$ is the electron diffusion
current from the $p^+$ to the $i$ region, $I_{nnh}$ is the hole diffusion current from the $n^+$ to the $p$
region and $q$ is the magnitude of the electron charge.

In the $i$ region, both electrons and holes are considered as minority carriers, and the
rate of increasing any type of these carriers will be equal to the photo-generation rate in
this region plus the impact ionization rates initiated by any electrons or holes minus the
recombination rate. Also, for electrons this process will be affected by the electron
diffusion and drift from the $p^+$ region and to the $p$ region respectively. For holes, it will be
affected by the hole drift from and to the $p$ and $p^+$ regions respectively. Therefore, the rate
equation for electrons in the $i$ region has the form
\[
\frac{dP_{ie}}{dt} = G_{i} + v_{ie} \zeta_{ie} P_{ie} + v_{ih} \zeta_{ih} P_{ih} + \frac{I_{ppe}}{q} - \frac{P_{ie}}{\tau_{ier}} - \frac{P_{ie}}{\tau_{iet}},
\]  
\(2.10\)

where $v_{ie}$ and $v_{ih}$ are the electron and hole velocity in the $i$ region, $\zeta_{ie}$ and $\zeta_{ih}$ are the
electron and hole impact ionization rates and $\tau_{ier}$ and $\tau_{iet}$ are the electron recombination
life-time and electron transient time in the i region respectively. For holes, the rate
equation is

$$\frac{dP_{lh}}{dt} = G_i + \nu_{lh} \tau_{lh} P_{lh} + \nu_{ie} \tau_{ie} P_{ie} + \frac{P_{ph}}{\tau_{phr}} - \frac{P_{lh}}{\tau_{lhr}}, \quad (2.11)$$

where $\tau_{phr}, \tau_{lhr}$ and $\tau_{lhr}$ are the hole transient time in the $p$ region, hole recombination life
time in the $i$ region and the hole transient time in the $i$ region respectively. It should be
noted that equations (10) and (11) are equal due to the charge neutrality condition. For the
reach-through APD, the impact ionization terms can be neglected and the photo-
generation and drift terms are the dominant. This assumption is not valid for the SLIK
structure APD since the electric field in that region is relatively higher causing the impact
ionization to occur earlier.$^{31}$

Finally, since the $p$ layer is lightly doped, both electrons and holes will be
considered as minority carriers, and the rate equations will be similar to that of the $i$
region and are given by

$$\frac{dP_{pe}}{dt} = G_p + \nu_{pe} \tau_{pe} P_{pe} + \nu_{ph} \tau_{ph} P_{ph} + \frac{P_{it}}{\tau_{set}} - \frac{P_{pe}}{\tau_{per}} \quad (2.12)$$

and

$$\frac{dP_{ph}}{dt} = G_p + \nu_{ph} \tau_{ph} P_{ph} + \nu_{pe} \tau_{pe} P_{pe} + \frac{I_{inh}}{q} \frac{P_{ph}}{\tau_{phr}} - \frac{P_{ph}}{\tau_{phr}}, \quad (2.13)$$

where $\tau_{pe}$ and $\tau_{ph}$ are the electron and hole impact ionization rates in the $p$ region, $\tau_{set}, \tau_{per}$
and $\tau_{pet}$ are the electron transient time in the $i$ region, recombination life-time in the $p$
region and transient time in the $p$ region respectively and $\tau_{phr}$ is the hole recombination
life-time in the $p$ region. Also, due to the charge neutrality condition, equations (2.12) and
(2.13) are equal. The dominant terms in these relations will be the impact ionization and the drift terms for both the reach-through and SLIK APDs, while the absorption term can be neglected especially for deep devices.

2.2.2. Continuity equations

The diffusion current from the p⁺ layer can be obtained by applying the continuity equation which is given by

\[ D_e \frac{d^2 n_e}{dx^2} - \frac{(n_e - n_{eo})}{\tau_{ppe}} + \frac{g_{pp}(x)}{A} = 0, \quad (2.14) \]

where \( D_e \) is the electron diffusion coefficient in the p⁺ region, \( n_e \) is the electron density profile, \( n_{eo} \) is the electron equilibrium density and \( A \) is the device area. The boundary conditions for this layer are; at \( x = 0, n_e = n_e(0) \) and at \( x = W_p, n_e = 0 \). If \( L_{pp} \) is the diffusion depth in the p⁺ region, the diffusion coefficient is given by

\[ D_e = \frac{L_{pp}^2}{\tau_{ppe}}, \quad (2.15) \]

and \( g_{pp}(x) \) is photo-generation rate of the charge carriers along the depth of the p⁺ layer.

Referring to equation (2.3), \( g_{pp}(x) \) is given by

\[ g_{pp}(x) = G_1 \cdot \alpha_{pp} \cdot \exp(-\alpha_{pp}x) ; 0 \leq x \leq W_p. \quad (2.16) \]

The solution of equation (2.14) is given by

\[ n_e(x) = n_{eo} + c_1 \exp(-\alpha_{pp}x) + \left[ n_e(0) - n_{eo} - c_1 \right] \frac{\sinh \left( \frac{W_p - x}{L_{pp}} \right)}{\sinh \left( \frac{W_p}{L_{pp}} \right)} - \left[ n_{eo} - c_1 \exp(-\alpha_{pp}W_p) \right] \frac{\sinh \left( \frac{x}{L_{pp}} \right)}{\sinh \left( \frac{W_p}{L_{pp}} \right)} \quad (2.17) \]

where \( c_1 \) is a constant given by
To evaluate \( n_e(0) \), equation (2.17) is applied to the condition

\[
P_{pp} = A \int_0^{w_{pp}} (n_e - n_{eo}) \, dx.
\]

(2.19)

and solving for \( n_e(0) \) and substituting its value in equation (2.17), the electron diffusion current from the \( p^+ \) region can be determined from

\[
I_{pe} = +qAD_e \frac{dn_e}{dx} \bigg|_{x=W_{pp}}.
\]

(2.20)

Similarly, to evaluate the hole diffusion current \( I_{nn} \) from the \( n^+ \) region, we apply the hole continuity equation which is given by

\[
D_h \frac{d^2n_h}{dx^2} - \left( \frac{n_h - n_{eo}}{\tau_{nn}} \right) + \frac{g_{nn}(x)}{A} = 0,
\]

(2.21)

where \( D_h \) is the hole diffusion coefficient in the \( n^+ \) region, \( n_h \) is the hole density profile and \( n_{eo} \) is the hole equilibrium density. The boundary conditions in this region are at \( x = 0, \ n_h = 0 \) and at \( x = W_{nn}, \ n_h = n_n(0) \). The hole diffusion coefficient can be obtained using the diffusion length \( L_{nn} \) in the \( n^+ \) region by

\[
D_h = \frac{L_{nn}^2}{\tau_{nn}}.
\]

(2.22)

and \( g_{nn}(x) \) is photo-generation rate of the charge carriers along the \( n^+ \) layer depth. Referring to (2.3) \( g_{nn}(x) \) is given by

\[
g_{nn}(x) = G_1 \cdot \exp\left( -\alpha_{pp} W_{pp} - \alpha_i W_i - \alpha_p W_p \right) \cdot \alpha_{nn} \cdot \exp\left( -\alpha_{nn} x \right); \ 0 \leq x \leq W_{nn}
\]

(2.23)

The solution of equation (2.21) is:
where \( c_i \) is a constant given by

\[
\sinh \left( \frac{W_{nn}}{L_{nn}} - x \right)
\]

\[
- \frac{[n_{ho} - c_2]}{\sinh \left( \frac{W_{nn}}{L_{nn}} \right)}.
\]

Similarly, to evaluate \( n_h(0) \) we use

\[
P_{m,n} = \int_0^{w_{pp}} (n_h - n_{ho}) \, dx.
\]

Substituting its value in equation (2.21), we get a complete expression for the hole density in the \( n^+ \). The hole diffusion current will then be evaluated using

\[
I_{n_h} = -qAD_h \left. \frac{dn_h}{dx} \right|_{x=0}.
\]

### 2.2.3. Avalanche photodiode equivalent circuit

For the purpose of constructing an equivalent circuit for the APD, we assume a constant \( C_o \) which is equivalent to a capacitor. Referring to equations (2.4), (2.5), (2.6) and (2.7), equations (2.8), (2.9), (2.10) and (2.13) can be written respectively as

\[
A_{pp} = \frac{P_{in}}{V_{pp}} = C_o \frac{dV_{pp}}{dt} + \frac{V_{pp}}{R_{pp}} + I_{pp}.
\]
\[ I_{\text{on}} = \frac{P_{\text{in}}}{V_{\text{on}}} = C_0 \frac{dV_{\text{en}}}{dt} + \frac{V_{\text{en}}}{R_{\text{nn}}} + I_{\text{nah}} \]  
(2.29)

\[ I_{\alpha} = \frac{P_{\text{in}}}{V_{\alpha}} = C_0 \frac{dV_{i}}{dt} + \frac{V_{i}}{R_{\text{ir}}} + \frac{V_{i}}{R_{\text{it}}} - I_{\text{ppe}} - I_{\text{is}} \]  
(2.30)

\[ I_{\text{op}} = \frac{P_{\text{in}}}{V_{\text{op}}} = C_0 \frac{dV_{p}}{dt} + \frac{V_{p}}{R_{\text{pr}}} + \frac{V_{p}}{R_{\text{pt}}} - I_{\text{nah}} - I_{\text{ps}} \]  
(2.31)

where the excess charge carriers are converted to voltages, using \( C_0 \), and are given by

\[ V_{\text{pp}} = q \frac{P_{\text{ppe}}}{C_0}, \quad V_{i} = q \frac{P_{\text{pi}}}{C_0}, \quad V_{\text{p}} = q \frac{P_{\text{ph}}}{C_0}, \quad \text{and} \quad V_{\text{en}} = q \frac{P_{\text{nah}}}{C_0} \]  
(2.32)

The rest of the parameters are given by

\[ V_{\text{opp}} = \frac{1}{q} \frac{P_{\text{in}}}{G_{\text{pp}}}, \quad V_{\alpha} = \frac{1}{q} \frac{P_{\text{in}}}{G_{i}}, \quad V_{\text{op}} = \frac{1}{q} \frac{P_{\text{in}}}{G_{\text{p}}}, \quad \text{and} \quad V_{\text{on}} = \frac{1}{q} \frac{P_{\text{in}}}{G_{\text{nn}}} \]  
(2.33)

\[ R_{\text{pp}} = \frac{\tau_{\text{ppe}}}{C_0} \]  
(2.34)

\[ R_{\text{nn}} = \frac{\tau_{\text{nah}}}{C_0} \]  
(2.35)

\[ R_{\text{ir}} = \frac{\tau_{\text{ire}}}{C_0}, \quad R_{\text{it}} = \frac{\tau_{\text{ite}}}{C_0} \]  
(2.36)

\[ I_{\text{is}} = C_0 V_i (v_{\text{ie}} \zeta_{\text{ie}} + v_{\text{ih}} \zeta_{\text{ih}}) \]  
(2.37)

\[ R_{\text{pr}} = \frac{\tau_{\text{pre}}}{C_0}, \quad R_{\text{pt}} = \frac{\tau_{\text{pte}}}{C_0} \]  
(2.38)

\[ I_{\text{ps}} = C_0 V_p \left( v_{\text{pe}} \zeta_{\text{pe}} + v_{\text{ph}} \zeta_{\text{ph}} \right) \]  
(2.39)

The diffusion currents \( I_{\text{ppe}} \) and \( I_{\text{nah}} \) will be given respectively by

\[ I_{\text{ppe}} = \frac{V_{\text{pp}}}{R_{\text{pd}}} + \beta_p P_{\text{in}} + I_{\text{ppeo}} \]  
(2.40)
\[ I_{\text{coh}} = \frac{V_{\text{nn}}}{R_{\text{pd}}} + \beta_p P_{\text{in}} + I_{\text{coh}}, \quad (2.41) \]

where

\[ R_{\text{pd}} = R_{\text{pp}} \left[ \cosh \left( \frac{W_{\text{pp}}}{L_{\text{pp}}} \right) - 1 \right] \quad (2.42) \]

\[ R_{\text{nd}} = R_{\text{nn}} \left[ \cosh \left( \frac{W_{\text{nn}}}{L_{\text{nn}}} \right) - 1 \right] \quad (2.43) \]

\[ \beta_p = q \frac{(1 - R)}{\hbar c} \lambda \frac{\alpha_{\text{pp}} L_{\text{pp}}^2}{(1 - \alpha_{\text{pp}}^2 L_{\text{pp}}^2)} \left\{ \alpha_{\text{pp}} \exp(-\alpha_{\text{pp}} W_{\text{pp}}) + \frac{[\exp(-\alpha_{\text{pp}} W_{\text{pp}}) - 1]}{\alpha_{\text{pp}} L_{\text{pp}}^2 \left[ \cosh \left( \frac{W_{\text{pp}}}{L_{\text{pp}}} \right) - 1 \right]} \right\} \quad (2.44) \]

\[ \beta_n = q \frac{(1 - R)}{\hbar c} \lambda \frac{\alpha_{\text{nn}} L_{\text{nn}}^2}{(1 - \alpha_{\text{nn}}^2 L_{\text{nn}}^2)} \exp(-\alpha_{\text{pp}} W_{\text{pp}} - \alpha_{\text{pp}} W_{\text{pp}} - \alpha_{\text{pp}} W_{\text{pp}}) \left\{ \frac{[\cosh \left( \frac{W_{\text{nn}}}{L_{\text{nn}}} \right) + 1]}{L_{\text{nn}} \sinh \left( \frac{W_{\text{nn}}}{L_{\text{nn}}} \right)} \right\} \quad (2.45) \]
Using equation (2.28) through (2.31) and the definition of the diffusion currents given in equations (2.40) and (2.41), the APD equivalent circuit can be constructed as shown in Figure 2.3. The APD output current, $I_{APD}$, will be given by

$$I_{APD} = I_{ppe} + I_t + I_p + (C_s + C_j) \frac{dV_{BIAS}}{dt} + I_d,$$

(2.48)

where

$$I_t = \frac{V_t}{R_t},$$

(2.49)

$$I_p = \frac{V_p}{R_p},$$

(2.50)

and $C_s$ and $C_j$ are the parasitic and junction capacitance, $I_d$ is the sum of the leakage and tunneling currents and $V_{BIAS}$ is the applied APD bias voltage.
Figure 2.3 APD equivalent circuit
2.3. Model validation

In order to validate the discussed model, a silicon reach-through APD was simulated. The APD is manufactured by EG&G (model number C30902E). Table 2.1 gives some parameters of this APD as well as for silicon at a temperature of 300 K.

<table>
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<th>Parameter</th>
<th>Value</th>
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</thead>
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<td>A (mm$^2$)</td>
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</tr>
<tr>
<td>$W_{pp}$ (μm)</td>
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</tr>
<tr>
<td>$W_l$ (μm)</td>
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</tr>
<tr>
<td>$W_p$ (μm)</td>
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</tr>
<tr>
<td>$W_{nn}$ (μm)</td>
<td>10</td>
</tr>
<tr>
<td>R</td>
<td>0.35</td>
</tr>
<tr>
<td>$N_A$ (cm$^{-3}$)</td>
<td>5x10$^{12}$</td>
</tr>
<tr>
<td>$N_D$ (cm$^{-3}$)</td>
<td>5x10$^{12}$</td>
</tr>
<tr>
<td>$N_i$ (cm$^{-3}$)</td>
<td>1.5x10$^{10}$</td>
</tr>
<tr>
<td>$D_e$ (cm$^2$s$^{-1}$)</td>
<td>34.2</td>
</tr>
<tr>
<td>$D_h$ (cm$^2$s$^{-1}$)</td>
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</tr>
<tr>
<td>$\tau_{ppe}$ (μs)</td>
<td>30</td>
</tr>
<tr>
<td>$\tau_{nnh}$ (μs)</td>
<td>20</td>
</tr>
<tr>
<td>$\tau_{ier}$ (μs)</td>
<td>30</td>
</tr>
<tr>
<td>$\tau_{pht}$ (μs)</td>
<td>20</td>
</tr>
</tbody>
</table>

2.3.1. Model parameters

The values of the electric field were approximated by two step functions under the constraint of equal bias voltage for both the simulated and approximated profiles shown earlier in Figure 2.2b and 2.2c. The electric field step function relates to the applied bias voltage by

$$E_i = \frac{V_{bias}}{(W_l + 6.5W_p)} \quad \text{and} \quad E_p = 6.5E_i.$$  (2.51)
where $E_i$ and $E_p$ are the electric in the $i$ and $p$ layers respectively. Since the device built-in potential is neglected, these relations are only valid near the breakdown bias voltage of the APD.

The impact ionization coefficients for electrons and holes as a function of the electric field in the range of $2 \times 10^5$ to $5 \times 10^5$ V/cm were obtained from ref. 41 and applied for the $i$ and $p$ regions.

The electron and hole drift velocity can be obtained as a function of the electric field from the empirical formula

$$v = v_s \left( \frac{E/E_c}{1 + (E/E_c)^\beta} \right)^{\frac{1}{\beta}},$$

(2.52)

where $v_s$ is the carrier saturation velocity, $E_c$ is the critical field defined by the ratio of the carrier saturation velocity to its mobility and $\beta$ is a constant. The values of the saturation velocity, mobility and the constant $\beta$ are $1 \times 10^7$ and $0.8 \times 10^7$ cm/s, 1320 and 460 cm$^2$/Vs and 0.9 and 0.8 respectively for electrons and holes.

The absorption coefficients for the various layers were assumed the same. The absorption coefficient as a function of the wavelength of the incident light was taken from ref. 42 for the 800 to 1100 nm wavelength range. The data were fitted using polynomial fit and applied to the model.

2.3.2. Steady state performance

The spectral response of the APD under investigation was obtained from the manufacturer data sheet and is shown in Figure 2.4 at a temperature of 295 K.\textsuperscript{34} Also shown in the same figure the spectral response obtained after applying the model to the
same device assuming a 215 V bias voltage and 300 K temperature. Comparing the two curves we note that the model spectral response has a lower responsivity values with a maximum near the 870 nm. The responsivity $R$ was obtained using the relation.

$$ R = \frac{I_{\text{APD}}}{P_{\text{in}}} . $$  \hspace{1cm} (2.53)

![Figure 2.4 APD spectral response obtained from the manufacturer data sheet at 295 K and from the model at 300 K and 215 V.](image)

The quantum efficiency variation with wavelength is shown in Figure 2.5 obtained from the manufacturer and the model.\textsuperscript{21,34} In order to obtain this relation, the model was run while setting the impact ionization coefficients to zero. Therefore, the responsivity gave a measure to the quantum efficiency $\eta$ according to the relation.

$$ \eta = \frac{hc}{q\lambda} R_{\text{lg}=1} . $$ \hspace{1cm} (2.54)
Although the results of figures 2.4 and 2.5 indicate the lack of accuracy in the model parameters, the device gain variation with respect to wavelength can be predicted at the given operating voltage. The accuracy of the model parameters is very critical in the model stability and results, especially in the multiplication region, as will be shown later.

Figure 2.6 shows the responsivity variation with bias voltage obtained form ref. 34 and the model both assuming constant wavelength of 830 nm.21,34 The model result indicates that the APD bias voltage of 215 V is near-breakdown voltage which is about 8 V less than the manufacturer corresponding voltage at similar temperature.

As shown in Figure 2.6, the large deviation between the simulated results and the manufacturer data at low operating bias voltage was expected. This was indicated earlier in equation (2.51) since the natural built-up potential is neglected. This affects the impact ionization rate leading to decrease of the responsivity at lower voltage biases.
To demonstrate the model sensitivity to the device multiplication width, \( W_p \), referring to (2.13) we can define a multiplication stability constant \( C_{MS} \) as

\[
C_{MS} = v_{ph} \zeta_{ph} + v_{pe} \zeta_{pe} - \frac{1}{\tau_{ph}} - \frac{1}{\tau_{ph}},
\]

(2.55)

in which the electron impact ionization and the hole transient time terms are the dominant. The value of this constant determines the stability of the device since it controls the feedback of the multiplication process. Figure 2.7 investigates the variation of the stability constant and the resulted responsivity with the width of the multiplication region \( W_p \). The values of the multiplication stability constant shown to the left of the stability limit line are positive while the values to the right are negative. \( W_p \) affect the hole transient time according to

\[
\tau_{ph} = \frac{W_p}{v_{ph}}.
\]

(2.56)
It was found that any positive values of $C_{MS}$ causes model failure because it causes an unstable positive feedback. Although the magnitude of the negative values of $C_{MS}$ controls the APD gain and thus its responsivity, the practical value of the responsivity lies within a small region of the multiplication width. The bias voltage is another factor affecting the multiplication stability constant, since it controls both the charge carrier velocity and impact ionization coefficients. This explains the sudden increase of the responsivity with bias voltage as shown in Figure 2.6.

Practically, when manufacturing these devices, it is very hard to keep the multiplication width consistent. This explains why similar APD part numbers from the same manufacturer have different operating bias voltages with different characteristics.\textsuperscript{22}

The value of the responsivity is also affected by the initial doping concentration of the donor atoms in the $n^+$ region. As shown in Figure 2.8, at a constant acceptor concentration, increasing the doping level of the donors reduces the responsivity. A doping level of $5 \times 10^{12}$ is a reasonable limit for manufacturing devices with similar characteristics as the device under investigation. Shown in the same figure the effect of the acceptor atoms doping concentration in the $p^+$ region, at constant donor concentration, which has a smaller effect.
Figure 2.7 Responsivity and multiplication stability constant variation with the multiplication width, obtained at 800 nm wavelength and 215 V bias.

Figure 2.8 Donor and acceptor concentration effect on the APD responsivity at 800 nm wavelength and 215 V bias voltage.

As pointed out by applying the continuity equation, increasing the donor concentration increases the electron diffusion current to the absorption region. This has
the effect of increasing the recombination rate with holes leading to decrease the photo generated carries (holes) resulting in responsivity reduction. Increasing the donor level more, responsivity saturation will be resulted, since the diffused electrons recombined with all the generated holes. A similar effect occurs due to the increase of the acceptor level. However, since the acceptor diffusion current take place in the multiplication region where the photo charge carriers got multiplied, it has a lower effect on the responsivity.

One application of this model is to study the effect of different APD parameters on its characteristics. This is demonstrated in Figure 2.9, which gives the effect of changing the width of the i or absorption region on the spectral response. By increasing the absorption depth the spectral response curve shifts to the infrared. Referring to equation (2.51), the degradation of the peak points is due to the considerable reduction in the electric field of the absorption region, $E_i$, since the bias voltage was assumed constant (215 V) for all cases. This spectral response shift is known commercially as infrared enhanced APDs.

The value of the absorption width, $W_j$, is limited by two main factors. Reducing $W_i$ to a low value limits the absorption depth and the acceleration distance required by the charge carriers to gain sufficient energy for the impact ionization process. On the other hand, increasing $W$ to large value causes losses in the carriers due to recombination.
2.3.3. Transient performance

To test the APD model in the transient state, an input optical pulse was simulated and applied to the model. This pulse had a square waveform with 100 ps duration and 1 μW amplitude at 800 nm. The APD output current is shown in Figure 2.10 for different operating bias voltage. The rise time was observed to be constant at about 80 ps. The fall times were 450 and 780 ps for 140 and 215 V bias voltages respectively. This indicates that the rise time has a negligible variation with bias voltage, while the fall time increases with the increase in the voltage. The rise time generally depends on the speed of the photon absorption process within the device; therefore, it has nothing to do with the bias voltage. On the other hand, the bias voltage affects the speed of the charge carriers and their number. That’s why it affects the fall time. The sudden changes in the APD current

Figure 2.9 Spectral response variation with the width of the absorption region obtained at 300 K and 215 V.
shown in Figure 2.10 at the rising and falling instances are due to the sharp edges of the square wave of the simulated input power.

Figure 2.10 APD output current with a square wave input power of 100 ps duration and 1 μW amplitude at 800 nm, obtained at 140 and 215 voltage biases.

This model is also suitable for performing some tests to the APD which are practically destructive to the device. Figure 2.10 shows the simulated APD output current during breakdown. This was simulated assuming an applied bias voltage of 215.7 V and a step input power of 1 μW as shown in the same figure. The breakdown time, shown in the same figure, was defined as the time interval between applying the input power and the rapid increase of the APD current up to 10% of its normal value at starting. The 10% value was suitable enough since the APD current has a rapid increase to infinity indicating device damage. Figure 2.11 shows the relation between the magnitude of the...
breakdown voltage and the breakdown time indicating that increasing the applied breakdown voltage speeds up the breakdown time.

Figure 2.11 APD output current during breakdown simulated with an applied voltage bias of 215.7 V and a step input power of 1 μW. The breakdown time is defined as the time interval between applying the input power and the increase of the APD current up to 10% of its steady-state value.

Figure 2.12 APD breakdown time variation with breakdown voltage bias.
For low light detection, an APD can be operated in the Geiger mode or photon counting. In this mode, the device is biased with a voltage above its breakdown value leading to increase the device gain. Therefore, it will be very sensitive and any absorption of a small amount of photons will cause avalanche breakdown which can be detected as current pulse. In this mode of operation, it is important to apply such over-breakdown bias for short time intervals known as the counting bin to control the avalanche breakdown. Increasing the counting bin will cause damage to the device.

Although the switching action was assumed to the input power, the characteristics shown in Figure 2.11 is important for defining the bin duration for an APD operating in the Geiger mode. With the current model, switching the bias voltage was difficult to obtain. This is due to the dependence of many parameters on the bias voltage which had to be calculated before starting the simulation.

2.3.4. Model conclusion and limitations

A drift-diffusion model for four layer APDs has been developed. This model is a modification of the Chen and Liu PIN-APD model. The model was used to drive an APD equivalent circuit and can be used to simulate the device transient and steady state response. For the validation purpose the model parameters were chosen as close as possible to an actual device. Reasonable agreement between the model results and the manufacturer data sheet indicated the validity of the model. This model can be used for device structure modification as to enhance the spectral response of a device or for destructive tests such as breakdown.
There were many assumptions associated the construction of this model which make it limited. The limitations of the model include the effect of temperature, low bias voltage operation, simulation of the device characteristics and response near saturation and noise modeling.
CHAPTER III

AVALANCHE PHOTODIODE:
CHARACTERIZATION AND SELECTION

A group of silicon based avalanche photodiode (APD) detectors, with different structures, were characterized from different manufacturers. The main concern in these experiments was to calibrate these APDs and to investigate the influence of their high voltage bias and temperature on the APD responsivity and to examine their active area uniformity and noise performance. With these results, an optimal detector was chosen for the new atmospheric water vapor DIAL detection system. The detection system can operate at 720, 820 or 940 nm wavelengths which correspond to water vapor absorption lines.

The APDs that were characterized are given in Appendix A as well as a summary of the characterization results. The results of the reach-through structure (RTS) APD C30955E currently used in the LASE instrument and the super low ionization coefficient (SLIK) APD C30649E will be discussed in detail in this chapter. Both APDs are manufactured by EG&G.

3.1. Experimental setup

The experimental setup for the APD responsivity calibration is shown in Figure 3.1. The light source was a broad-band halogen lamp supplied by a stabilized power supply to insure stable spectrum and intensity. The lamp output is filtered by a 600-nm long-pass filter to prevent higher order dispersion of shorter wavelengths from being collected in
first-order dispersion in the range of 600 to 1100 nm. The chopper was used to modulate the optical signal for dc offset elimination at the detector output and to allow for phase-locked detection. The monochromator was used to separate the light input into its spectral components. An integrating sphere was used to diffuse the exiting light to insure uniform intensity at the detector.22,45,47,50

Figure 3.1 APD experimental setup for the spectral response determination.

The APD output was filtered by a high-pass filter to eliminate dark current and background radiation offsets. An oscilloscope was used to check the detected signal and to obtain its peak-to-peak value, \( V_{\text{pp}} \), and a lock-in amplifier was used to accurately measure the signal rms value, \( V_{\text{lock-in}} \). The chopper controller adjusted the chopping frequency to 200 Hz and supplied synchronization signals for the other instruments.22,45

The APDs are biased using a high voltage source. The APD current variation, representing the change in the light intensity, was converted to a voltage signal using a

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trans-impedance amplifier (TIA).\textsuperscript{24-27,51-52} The TIA configuration is shown in Figure 3.2a, where $R_f$ is the amplifier feedback resistance and $R$ and $C$ act as a low pass filter to eliminate any bias voltage ripples. The test detector was placed on a printed circuit board and put inside a chamber, as shown in Figure 3.2b. The chamber was located on a three-dimensional, computer-controlled, translation stage for alignment. Nitrogen gas flow was used to prevent condensation of water vapor on the detector window at low temperature and to avoid dust accumulation. A temperature controller and a thermoelectric cooler (TEC) were used to fix the temperature of the APD under test.\textsuperscript{53} Water circulation provided forced cooling to the TEC for low temperature settings. The APD temperature was measured with a temperature sensor and a digital voltmeter. A personal computer sent commands to the monochromater to adjust the wavelength for the spectral scan, and it acquired the lock-in amplifier and the temperature readings using a GPIB data acquisition card.\textsuperscript{52,47}

![Detector Chamber](image)

Figure 3.2 (a) APD bias circuit and the trans-impedance amplifier connection (b) APD chamber used to mount and stabilize the device temperatures.
The APD spectral response was measured over a 600 to 1100 nm wavelength range. Comparison was made with a NIST (National Institute of Standards and Technology) calibrated reference detector by placing each detector in the same uniform light field at the same position. The distance between the light outlet and the detector active area was 150 mm. For alignment purposes, a microscope with a 200 μm depth of focus was used to position all detectors as shown in Figure 3.3. Applying the inverted square function, the worst-case deviation of the intensity at the detector was ±0.53 %. Errors due to positioning of the detectors can cause absolute calibration uncertainty of less than 1%. The microscope was placed on a kinematic mount (1μm placement precision) so that it could be removed from the optical path during the wavelength scan and precisely replaced in the path for detector positioning.\textsuperscript{22,47}

Figure 3.3 APD alignment setup using microscope.

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3.2. Avalanche photodiode calibration

The slits of the monochromator were adjusted to have a wavelength band-pass of 10 nm. Because the halogen spectral maximum output was at 690 nm, the monochromator was set at this value and the chopping factors were determined for both the reference and test detectors using the relation

\[ CF = \frac{V_{\text{lock-in}}}{V_{\text{p-p}}} . \]  

(3.1)

Knowing the spectral response of the reference detector, shown in Figure 3.4a, the responsivity of the test detectors was determined by comparison using the relation

\[ \mathcal{R}_d = \frac{V_{d(\text{lock-in})}}{V_{r(\text{lock-in})}} \cdot \frac{\mathcal{R}_r \cdot R_r}{\mathcal{R}_d \cdot R_d} \cdot \frac{A_d}{A_r} \]  

(3.2)

at each wavelength increment of 10 nm, where \( \mathcal{R}_r \) and \( \mathcal{R}_d \) are the responsivity of the reference detectors and test detector respectively, \( V_{r(\text{lock-in})} \) and \( V_{d(\text{lock-in})} \) are their output voltages, all at the same wavelength. \( CF_r \) and \( CF_d \) are the chopping factors, \( R_r \) and \( R_d \) are the feedback resistors and \( A_r \) and \( A_d \) are the sensitive areas of the reference and test detectors respectively.\(^{22,47}\)

The spectral response of the tested detectors is shown in Figure 3.4b. To compare the results with the manufacturer data sheets, room temperature and manufacturer specified bias voltage were used. The APD responsivity is directly proportional to the wavelength of the incident light.\(^{24-27,54}\) This is true as indicated in Figure 3.4, for wavelengths from 600 nm to the point where the response begins to roll off. Ideally, the roll off point would be sharp and correspond to the energy band-gap of silicon. At this cutoff, the responsivity decreases sharply due to insufficient energy in the incident
photons for the generated electrons to overcome the band-gap energy, resulting in reduction of the APD quantum efficiency. The deviation from the ideal cutoff found in our characterized APDs was mainly due to charge collection inefficiency of photons outside the depletion region of the APD which was dependent on the type and level of the doping materials used to manufacture the device.\(^{28}\)

![Figure 3.4 Spectral response of the (a) reference detector and (b) test detectors.](image)

3.3. Temperature dependent responsivity

At fixed bias voltage and wavelength, the responsivity of an APD detector increases with decreasing temperature. Low temperature operation of an APD leads to an increased output signal due to the increase in the device gain. Low temperature operation also decreases the dark current noise level, which results in increasing the detector signal-to-noise ratio.\(^{26-27,55-58}\)

Experiments investigating the effect of APD temperature on the spectral response were performed. An empirical relationship for the responsivity versus temperature was
obtained. The nitrogen gas purge and the water circulation allowed the APD operating 
temperature to be adjusted from nearly 0 °C to room temperature. It is important to 
remember that a lower operating temperature causes the detector breakdown voltage to 
decrease; therefore, the APD voltage bias must be chosen carefully while performing this 
test to avoid device destruction. 22-47

The setup shown in Figure 3.1 was used but only for the test detectors in this 
experiment. During the experiment, the detector voltage bias was kept constant to insure 
that the spectral response variation is only due to changes in temperature. Using the 
alignment setup shown in Figure 3.3, the detector position with respect to the light source 
was adjusted to the same value of the responsivity calibration experiment to insure the 
same input light intensity.

The temperature controller shown in Figure 3.1 fixed the operating point for each 
spectral scan. For each temperature set point, the system was allowed to reach 
equilibrium before proceeding with the experiment. This whole procedure was repeated 
for each APD under investigation.

For each APD the following characterization results were presented:

- The APD detector output voltage variation with wavelength, \( V_n(\lambda) \)
- The APD temperature variation with wavelength, \( T_n(\lambda) \)

Ideally, the temperature should be kept constant during this experiment. This was not true 
in our case due to some deficiencies in the temperature controller used in the 
experimental setup. Therefore, we had to record the temperature for each wavelength 
increment \( T_n(\lambda) \). To obtain the APD temperature, \( T_n \), this data set was averaged 
according to 22

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\[ T_n = [T_n(\lambda)] \]  

(3.3)

At the same temperature \( T_n \) and using the calibration data, the detector output voltage variation was converted to a responsivity variation with respect to wavelength. This procedure was repeated for every temperature setting giving the spectral response variation with temperature shown in Figures 3.5a and 3.5b for the C30649E and C30955E, respectively.

Figure 3.5 APD spectral response and responsivity variation with temperature for the (a) SLIK C30649E and (b) RTS C30955E structures respectively.

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To obtain the responsivity variation with temperature, the analysis of the data starts by constructing a responsivity vector, \( \{ \mathcal{R}(T) \} \), and a temperature vector, \( \{ T \} \), at a certain wavelength, \( \lambda_x \), as shown in the following:

\[
\{ \mathcal{R}(T) \} = \{ \mathcal{R}_1(\lambda_x), \mathcal{R}_2(\lambda_x), \ldots, \mathcal{R}_n(\lambda_x), \ldots, \mathcal{R}_N(\lambda_x) \}
\]  \hspace{1cm} (3.4)

\[
\{ T \} = \{ T_1, T_2, \ldots, T_n, \ldots, T_N \}.
\]  \hspace{1cm} (3.5)

Applying a polynomial curve fit the responsivity variation with temperature at \( \lambda_x \), took the form

\[
\mathcal{R}(T)_{\lambda_x} = \sum_{m=0}^{M} a_m \cdot T^m,
\]  \hspace{1cm} (3.6)

where \( M \) is the curve fit order and \( N \) is the index for maximum temperature. The responsivity-versus-temperature relations for the SLIK and RTS APDs are shown in Figures 3.5c and 3.5d. The relations for the rest of the APDs are given in Appendix A.

This experiment determines the APD temperature stability requirements by obtaining the responsivity partial derivative with respect to temperature which is given by

\[
\left. \frac{\partial \mathcal{R}(T)}{\partial T} \right|_{\lambda_x} = \sum_{m=0}^{M} m \cdot a_m \cdot T^{(m-1)}.
\]  \hspace{1cm} (3.7)

For example, a temperature deviation (\( \Delta T \)) of 0.1 °C near an operating temperature of 10 °C for the 820 nm wavelength at rated bias voltage will result in a responsivity deviation of \( \Delta \mathcal{R} = 0.3 \) and 2.2 A/W, leading to a relative error of 0.4% and 1.2% for the SLIK and RTS structures, respectively. This indicates that the SLIK structure is more stable with respect to temperature variation. This fact is clear from Figure 3.6 which shows the relative error in the APD responsivity as a function of temperature at the three water vapor absorption wavelengths of interest, assuming a 1 °C temperature variation. Also
clear from this figure is that the responsivity relative error due to temperature variation does not depend that much on the operating wavelength.\textsuperscript{47}

![Figure 3.6 SLIK and RTS APD structures relative error in responsivity due to 1 °C temperature variation obtained at 720, 820 and 940 nm water vapor absorption wavelengths.]

3.4. Bias voltage dependent responsivity

At fixed temperature and wavelength, the responsivity of an APD increases with increasing bias voltage up to the breakdown voltage. This is due to the increased internal electric field leading to the transfer of more energy to the photo-charge carriers which enhances the impact ionization process. Bias voltage above breakdown causes rapid charge carrier generation which usually leads to device damage.\textsuperscript{24-47,59}

This experiment investigated the effect of the APD bias voltage variation on the spectral response and obtained a responsivity versus bias voltage relation at the water vapor DIAL wavelengths of interest. Similar to the previous experiment the setup shown
in Figure 3.1 was used for the test APDs. During the experiment, the APD temperature was kept constant to insure that the spectral response variation is only due to the bias voltage. The detector position with respect to the light source was adjusted to the same value of the responsivity calibration experiment to insure the same light intensity input.

Using the high voltage supply, the detector bias is set to a certain value and the temperature was stabilized by the temperature controller. Then, the output peak-to-peak voltage was measured using the oscilloscope and its rms value was measured using the lock-in amplifier to calculate the chopping factor. Next, the scan sequence started from 600 to 1100 nm with a step increment of 10 nm. For each step increment the wavelength, output voltage and temperature were recorded using the computer. Finally, the experiment was repeated for a set of different bias voltages. This procedure was repeated for each APD under investigation.

At the end of this experiment, each APD had a group of data files describing its output voltage variation with wavelength at a given bias voltage. The value of the bias voltage, $V_{bn}$, is measured directly from the high voltage supply. For a certain APD at a given bias voltage the available data was as follows:

- The APD detector output voltage variation with wavelength, $\{V_n(\lambda)\}$
- The APD temperature variation with wavelength, $\{T_n(\lambda)\}$

The detector output voltage variation was converted to responsivity variation with respect to wavelength using the calibration data. This procedure was repeated for every voltage bias setting giving the spectral response variation with bias voltage.
To obtain the responsivity variation with bias voltage at a certain wavelength \( \lambda_x \), we use the spectral response variation with bias voltage to form two vectors. A responsivity vector \( \{ R(V_B) \} \) and a voltage bias vector \( \{ V_B \} \) where defined as

\[
\{ R(V_B) \} = \{ R_1(\lambda_x), R_2(\lambda_x), \ldots, R_n(\lambda_x), \ldots, R_N(\lambda_x) \}
\]

(3.8)

\[
\{ V_B \} = \{ V_1, V_2, \ldots, V_n, \ldots, V_N \}
\]

(3.9)

Using a polynomial curve fit, the responsivity variation with bias voltage is given by

\[
R(V)_{\lambda_x} = \sum_{m=0}^{M} a_m \cdot V^m,
\]

(3.10)

where \( M \) is the curve fit order and \( N \) is the index for maximum voltage bias. This analysis was applied to each APD at 720, 820 and 940 nm wavelengths.\(^{22,47}\)

The experimental results are shown in Figure 3.7 for the C30649E and C30955E APDs. For each detector, the spectral response variation with bias voltage is shown on the set of curves to the left and the responsivity variation with bias voltage on the right. The results for the rest of the APDs are given in Appendix A.

To obtain the APD bias voltage stability, the partial derivative of the responsivity with respect to bias voltage is obtained from

\[
\frac{\partial R(V)}{\partial V} \bigg|_{\lambda_x} = \sum_{m=0}^{N} m \cdot a_m \cdot V^{(m-1)}.
\]

(3.11)

For example, with both APDs operating at their rated bias voltage and for a voltage deviation (\( \Delta V \)) of 1 V at 820 nm wavelength, the responsivity deviations (\( \Delta R \)) are 2.28 and 1.54 A/W for the SLIK and RTS APDs, respectively, which is a relative error of 4.6% and 2% for the SLIK and RTS structures, respectively. This indicates that the RTS structure is less sensitive to voltage variations. This fact is clear from Figure 3.8 which

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shows the relative error in the APD responsivity as a function of the bias voltage normalized to the APD rated bias. These relations are given at the three water vapor absorption wavelengths of interest assuming 1-V deviation in the bias voltage. Also clear from this figure is that the responsivity relative error due to bias voltage does not depend significantly on the operating wavelength.47

Figure 3.7 APD spectral response and responsivity variation with bias voltage for the (a) SLIK and (b) RTS structures respectively.
Figure 3.8 SLIK and RTS APD structures relative error in responsivity versus normalized bias voltage due to I-V deviation in the bias voltage obtained at 720, 820 and 940 nm water vapor absorption wavelengths.

3.5. Responsivity uniformity scan

The APD sensitive area can be considered as a group of point detectors distributed along its surface. Ideally, this distribution is uniform with each of these point detectors having the same responsivity for similar operating conditions; therefore, the overall responsivity distribution should be constant along the APD surface. Practically, this is not true due to defects in the APD manufacturing process.22,28

In this experiment, we investigated the uniformity of the APD responsivity along its surface and determined its active area. This can be achieved using a relatively small spot size light source and scan it across the detector area measuring the APD output voltage as a function of light spot position resulting in a responsivity map of the APD area. The small spot size light source was achieved using the setup shown in Figure 3.9. A 633-nm He:Ne laser was used to obtain a light beam which was focused by a microscope objective. The position of the detector was adjusted with the computer controlled three-
dimensional translation stage. The motion of the detector was adjusted so that the focused laser beam spot and the APD sensitive area remained in the same plane. A neutral density filter was used to avoid APD saturation.

The laser focusing optical system was calibrated to determine the displacement between the laser focus at its minimum waist and the visual focus of the microscope system shown in Figure 3.3. In order to obtain this calibration a pinhole was mounted on a three-dimension translation stage, as shown in Figure 3.10. The laser focus was determined by positioning the pinhole such that the maximum laser output was observed on the detector. The laser focus was measured with the micrometer on the translation stage. The visual focus was determined by viewing the best focus of the pinhole through the eyepiece. The test detectors were positioned by finding the visual focus of the detector surface and then translating to the laser focus by the calibrated displacement as described above. 

During the scan sequence, the detector moves in a two-dimension sequence with a fixed step size then the data is plotted and analyzed. The normalized surface scan results for the tested APDs are shown in Figure 3.11.

Figure 3.9 Responsivity uniformity scan setup.
In some DIAL systems, the light intensity is focused on a small region of the detector. Therefore, these surface scan data can be used to calculate the responsivity correction factor since the calibration of the APD considers the average responsivity over the entire detector active area. On the other hand, the surface scan data can be used to determine the APD hot spots which are points on the APD surface with very high responsivity relative to the average. The hot spots may cause a problem since at high light intensities the charge carriers concentration will increase at this position leading to increased power dissipation at this spot possibly resulting in local damage of the APD area.\textsuperscript{22}
The areas for the SLIK and RTS APDs were measured to be 0.238 and 1.692 mm$^2$ which is close to the manufacturer values of 0.25 and 1.5 mm$^2$, respectively. The non-uniformity of the APD surface was defined by the ratio of the standard deviation to the mean of the responsivity along the surface. The non-uniformity was measured to be 14.9% and 6.1% for the SLIK and RTS APD, respectively, which indicates that this particular RTS device is more uniform relative to the SLIK APD.

3.6. Noise measurement

The APD noise measurements were performed using a spectrum analyzer with a one Hz normalized spectrum at 10 kHz. Appropriate care was taken to insure that the detector dark current was the dominant noise source. The measured power spectral noise, $n$ (in dBm), was converted to the APD noise current spectral density, $I_n$, by the equation

$$I_n = \frac{\sqrt{10^{0.1n} \cdot R_L \cdot 10^{-3}}}{R_f},$$

(3.12)

where $R_L$ is a 50 $\Omega$ APD load resistance. Table 3.1 gives the noise current spectral density. The noise equivalent power (NEP) was obtained using the relation

$$\text{NEP} = \frac{I_n}{R_f}.$$  

(3.13)

The NEP for both SLIK and RTS APDs is shown in Figure 3.12. The SLIK structure shows a lower noise than the RTS. This might be due to the smaller detector area; thus, the figure-of-merit ($D^*$) was obtained for the tested detector at its responsivity calibration bias voltage and temperature using the relation

$$D^* = \frac{\sqrt{A}}{\text{NEP}}.$$  

(3.14)
This confirmed the fact that the SLIK structure has lower noise at shorter wavelengths up to about 950 nm. The results of this experiment are very important since it directly indicates that the SLIK would be the best detector for the water vapor DIAL detection system based on its lower noise.47

Table 3.1 APD noise measurement results.

<table>
<thead>
<tr>
<th>APD</th>
<th>(\lambda) Nm</th>
<th>(I_n) A/Hz(^{1/2})</th>
<th>NEP fW/Hz(^{1/2})</th>
<th>(D^*) cmHz(^{1/2})/W</th>
</tr>
</thead>
<tbody>
<tr>
<td>C30649E</td>
<td>720</td>
<td>2.3x10^{-13}</td>
<td>1.8</td>
<td>2.77x10^{13}</td>
</tr>
<tr>
<td></td>
<td>820</td>
<td></td>
<td>1.7</td>
<td>2.90x10^{13}</td>
</tr>
<tr>
<td></td>
<td>940</td>
<td></td>
<td>3.1</td>
<td>1.57x10^{13}</td>
</tr>
<tr>
<td>C30955E2</td>
<td>720</td>
<td>1.7x10^{-12}</td>
<td>28.0</td>
<td>4.75x10^{12}</td>
</tr>
<tr>
<td></td>
<td>820</td>
<td></td>
<td>22.2</td>
<td>5.99x10^{12}</td>
</tr>
<tr>
<td></td>
<td>940</td>
<td></td>
<td>19.4</td>
<td>6.84x10^{12}</td>
</tr>
</tbody>
</table>

Figure 3.12 SLIK and RTS APD structures noise-equivalent-power and figure-of-merit measurements as a function of wavelength obtained with rated bias voltage at room temperature.

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3.7. Frequency response

This experiment required the investigation of the responsivity variation of the SLIK APD with respect to the frequency of the input signal and to determine its cutoff frequency. This was done to check the manufacturer stated bandwidth and compare this bandwidth to the whole system bandwidth according to the Nyquist criterion. APDs have a very wide bandwidth in the order of giga-hertz, but due to the existence of the TIA in the APD package, the frequency response will be limited by the internal amplifier bandwidth which will be on the order of tens mega-hertz.

The experimental setup of Figure 3.1 was modified for the APD frequency response and shown in Figure 3.13. It consists of a 720-nm laser diode controlled by a pulse generator. The power supply is used to bias the laser diode driver circuit consisting of a buffer amplifier and a voltage-to-current converter. The output laser beam was split in order to apply part of the optical signal to the reference detector while the other part was applied to the test APD. The reference detector bandwidth was used to measure the input signal applied to the APD under test. Next, the output of both detectors was measured by a digital oscilloscope and a spectrum analyzer. The function of the oscilloscope was to check the magnitude of the output signal while the spectrum analyzer measured the frequency spectrum. When necessary, a neutral density filter was used to reduce the light intensity to avoid saturating the test APD. The electronic high pass filter was used to eliminate dc offsets in the detector output.

Using the setup discussed above and after aligning the optics, we set the APD bias voltage to its manufacturer specified value at room temperature. Then, we applied an optical signal to the detectors after choosing a suitable neutral density filter and checked
their output using the oscilloscope. Next, setting the frequency of the input optical signal to a certain value $f_i$, by using the pulse generator the amplitude of the fundamental frequency components of the APD input and the output signals, $R_i$ and $C_i$ respectively, are recorded in dBm using the spectrum analyzer. This corresponds to one data point in the frequency domain. By changing the frequency setting of the pulse generator and repeating the same procedures, we obtained the complete frequency scan starting from 100 kHz to 1 MHz, with frequency increments of 100 kHz for frequencies lower than 1 MHz, and a 1-MHz step for frequencies up to 20 MHz. The spectrum analyzer was set to a frequency range from 50 kHz to 20 MHz with each data point averaged 30 times.

![Frequency response experimental setup](image)

**Figure 3.13 Frequency response experimental setup.**

After collecting the data in the frequency range of interest, the analysis was done using MATLAB. First, the data was stored in three vectors, \{f\}, \{C\} and \{R\},
equivalent to the frequency increments and the corresponding outputs and inputs. Then, the gain vector \( \{G_i\} \), in \( \text{dB}_m \), was calculated for each frequency setting from

\[
G_i = C_i - R_i. \quad (3.15)
\]

The gain-frequency relation was obtained by applying a polynomial curve fit to the gain vector with respect to the frequency vector. By plotting this relation, we can obtain the cut-off frequency from the intersection between the curve and the -3dB line drawn from the low frequency gain.

The previous experiment was used to obtain the frequency response for the SLIK APD as mentioned above. The actual data and the curve fit of the frequency response are shown in Figure 3.14. The measured cutoff frequency was 12.75 MHz which is close to the manufacturer value (12 MHz).

3.8. Avalanche photodiode selection results

A group of APDs were characterized in order to chose a suitable detector for the new water vapor DIAL detection system. The characterization focused on two main APD structures, the reach through structure which is currently used in the LASE detection system and the newer SLIK structure. The SLIK structure APD showed better performance due to its lower noise, which will lead to an increase in the signal-to-noise ratio of the detection system by at least a factor of 10 over the current system.\(^{17}\) The EG&G SLIK APD package C30649E was selected because of the following advantages:

- Built-in, low noise, trans-impedance amplifier.
- Built-in thermoelectric cooler and thermistor for APD temperature control.
- The trans-impedance amplifier feedback resistance is cooled along with the detector, reducing the Johnson noise.

Figure 3.14 SLIK APD (a) input and (b) output variation with frequency and (c) frequency response obtained at 336V bias and 23 °C temperature.

A drawback in the selected APD arises from its small area (0.24 mm²) compared to the LASE APD (1.7 mm²) which might produce alignment difficulties. However, its lower noise strongly recommends it for the development of the new system.
CHAPTER IV
DETECTION SYSTEM DESIGN
AND LABORATORY PERFORMANCE

The main goal of this research effort is to increase the signal-to-noise ratio (SNR) of the water vapor DIAL detection system by a significant factor compared to the LASE instrument. Also, it is required to design the system to a compact size suitable for mounting directly on the receiver telescope with output data compatible with a simple computer interface. In this chapter, the design details of the water vapor DIAL detection system will be discussed, as well as its laboratory performance.

4.1. Detection system design

A block diagram of the new water vapor DIAL detection system is shown in Figure 1.2. The APD detected light signal is applied to the analog circuit shown in the block diagram of Figure 4.1. The analog circuit is designed to control the operation of the APD package and to condition its output signal in preparation for the 14-bit digitizer.

The laser return signal is focused onto the 0.5-mm diameter APD sensitive area. The APD output signal is applied to the signal conditioning stage, which consists of three substages. In DIAL applications, the transmitted laser pulses might hit a large amount of water vapor or aerosol layer, such as clouds, resulting in high levels of backscattered light which could overload the system. These overload signals are a major problem since they saturate the detector and cause "hanging" of the digitizer, which leads to loss of some data words. The clipping circuit is used to protect the digitizer by clipping these overload signals.
signals to a predefined level. For normal signals the clipping circuit acts as a voltage-follower amplifier. The APD overload is prevented using a current limiting resistor $R$ as shown in Figure 4.1.\textsuperscript{62}

![Block diagram of the analog circuit.](image)

Following this stage is a summer and buffer amplifier, designed to provide an additional gain to the detected signal in order to achieve a 2-V maximum peak-to-peak value which is compatible with the digitizer maximum input range. Also, it adds a marker and dither signals to the detected signal. The marker signal is used to mark the beginning of the useful data, while the dither is used to add a low level sinusoidal signal for better digitization performance.\textsuperscript{18,62}

Finally, the signal is applied to a Bessell filter, with a 2.5-MHz cutoff frequency. This filter limits the system bandwidth in order to reduce the high frequency noise and restrict the signal frequency with respect to the digitizing frequency according to the Nyquist criterion.\textsuperscript{39,51}
Since the APD responsivity is a strong function of its voltage bias and temperature, two proportional integral (PI) controllers were used. The first is a voltage controller which can be adjusted manually to apply a constant bias to the APD. The second is a temperature controller with a fixed set point. This controller is used to cool the detector with respect to the ambient temperature.

The output, detected signal from the analog circuit is applied to the digital circuit. The digital circuit was designed mainly to operate as a waveform digitizer but also performs some simple data processing such as averaging DIAL lidar return signals (hardware averaging) and monitoring the detection system performance. Figure 4.2 shows a block diagram of the main components of the digital circuit. The 14-bit, 10-MHz analog-to-digital converter (ADC) is used to convert the analog lidar signal from the detector to a digital format. The dual-port RAM is used for temporary data storage and it also isolates the 10-MHz digitizer frequency from the 16-MHz microcontroller frequency.

Figure 4.2 Block diagram of the digital circuit.

Approximately 400 µs before the DIAL laser fires, a trigger pulse is generated and is used as a precursor that informs other systems that the laser is about to fire. This pulse is sensed by the microcontroller and acts to synchronize the detection system with the
laser transmitter. A 10-Hz maximum laser firing frequency is assumed in this design, although a higher repetition rate could be accommodated. Also, the microcontroller will be used for on-line data averaging and house keeping.\textsuperscript{20}

Finally, the first-in-first-out (FIFO) memory is used to output the final data to the recording system. Again, the FIFO separates the 16-MHz microcontroller operating frequency from the output data transfer rate which is dependent on the computer interface. The computer interface used with the detection system was a parallel input-output interface with a maximum of 20 MSPS data transfer rate. This interface is fully controllable by C++ software. The final data is stored in an output file which is accessible with any other software package.

4.1.1. Analog circuit

The signal conditioning stage is the most critical stage in the whole detection system since any noise contribution from this stage to the detected signal will directly affect the useful data. Figure 4.3 shows the circuit diagram of this stage. In the text the various components of the system are referred to by their letter designation. Details of circuit schematics are given in Appendix B, and the component listing is given in Appendix C. Operational amplifier U7 is a clipping op amp which operates as a voltage follower for the detected signal provided that the signal lies within the clipping limits. The upper clipping limit is set to 2.5 V using R24 and R25. This limit is chosen only for the op amp stability and has no influence on the output since the detected signal coming from the APD package is always negative with a maximum theoretical value of zero. The lower clipping limit is set by a -1.5 V reference voltage (Appendix B). Resistor R26 acts
as the load resistance for the op amp as recommended by the manufacturer. The output of
the clipping op amp is then applied to U8 which is a gain and summer amplifier. Using
this op amp the signal gain is set to 3 using R27 and R26. Another gain of 0.5 is applied
to the signal using the R30 and R31 voltage divider, leading to a total end-to-end gain of
1.5 which was chosen so that the maximum APD output fit the maximum digitizer limit.
This voltage divider is used for termination according to the maximum power transfer
condition of Thevenin’s theorem. The summation of the marker and the dither inputs to
the detected signal is obtained using R28 and R29, respectively. 

Figure 4.3 Circuit diagram of the signal conditioning stage.

The final output is then filtered using U9 which is a 3 pole, 2.5-MHz, low-pass
Bessel filter. The Bessel filter was selected due to its excellent performance regarding
the phase shift for real time data. In order to check the output signal from this stage, the voltage across R31 can be accessed using an external connector. Also, this connector can be used to inject an external voltage to the digitizer according to the JP3 and JP4 jumper settings.65

Figure 4.4 shows the circuit diagram of the APD high voltage bias controller. The APD voltage bias is supplied from U4, a high voltage module. The control of the high voltage was obtained using U3, a dual op amp chip, with one op amp acting as the proportional controller set to a gain of 4 using R3 and R4 and the other as the integral controller set to an RC time constant of 0.04 s using R5 and C5. Diode D1 is used to ensure positive control voltage to U4. Potentiometer R7 is used to set the APD high voltage between 292 and 365 V. The output high voltage is applied to a low-pass filter formed by R8 and C8 to eliminate any bias ripples. In addition, R8 limits the APD current for overload protection, and C9 supplies it with instantaneous in-rush current. A potential divider formed by R9 through R13 is used as the voltage feedback to the controller. Voltage monitoring is obtained after the proportional controller with a voltage reading $V_{BM}$ related to the high voltage bias $V_{BIAS}$ by the equation$^{66,67,51}$

$$V_{BM} = \frac{V_{BIAS}}{14.91} - 20 . \quad (4.1)$$

The APD package was supplied from the manufacturer with a built in TEC cooler and a thermistor. The temperature status of the detector is sensed by the thermistor by placing it in an arm of a Wheatstone bridge formed by R15, R16, R17 and R18, as shown
Figure 4.4 APD voltage bias controller circuit diagram.

in the circuit diagram of Figure 4.5. The value of R18 determines the balance condition of the bridge therefore setting the detector temperature. Since the thermistor resistance $R_T$ is given by

$$R_T = 10^4 \cdot e^{\left( \frac{-3940}{T - 298} \right)}$$

and the bridge balance condition is

$$\frac{R_{15}}{R_{16}} = \frac{R_T}{R_{17} + R_{18}} = 1.$$  \hspace{1cm} (4.3)

Therefore, the temperature setting, in Kelvin, will be given by

$$T = \left( \ln \left( \frac{R_{18} + 33 \times 10^3}{10^4} \right) + \frac{1}{298} \right)^{-1}.$$  \hspace{1cm} (4.4)

Equation (4.4) indicates that the minimum temperature setting is selected by R17 (33 kΩ) and is equal to 0.3 °C with R18 short-circuited. Temperatures lower than this value usually cause problems due to condensation of water vapor on the detector window.
Zener diode D2 is used to supply the bridge by its zener voltage $V_Z$ equal to 5.1 V. The zener current limit is set by R14.\textsuperscript{53}

![Figure 4.5 APD temperature controller circuit diagram.](image)

The bridge balance is sensed by an instrumentation amplifier formed by the dual op amp U5,\textsuperscript{52} with one op amp acting as a voltage follower for the temperature monitor and the other acting as both the proportional integral controller with RC time constant of 0.02 s set by R19 and C10. The controller output is applied to a potentiometer R20 to set the TEC current by controlling the collector emitter current of the Darlington transistor Q1.\textsuperscript{68} Resistor R32 is a 10 W resistor used to set the maximum TEC current to 2 A according to its manufacturer specification. The temperature monitor voltage reading $V_{TM}$ will be given in terms of the zener voltage by\textsuperscript{53}

$$V_{TM} = \frac{R17 + R18}{R17 + R18 + R_T} V_Z.$$  \hfill (4.5)
After starting the circuit when the detector temperature reaches its steady state value the monitor voltage will be simply given by

\[ V_{TM} = \frac{1}{2} V_z. \]  

(4.6)

This voltage can be read directly using an output connector to indicate the temperature stability of the APD.\(^{53}\)

Referring to Figure 4.3, the conditioned analog signal “SIGNAL” will be applied to the digitizer, provided that both jumpers are shorted. A high input impedance instrument, such as an oscilloscope, can access this signal using the “CHECK” terminal.

4.1.2. Digital circuit

The conditioned analog signal was applied to a 14-bit, 10-MHz ADC, as shown in the block diagram of Figure 4.6. The input digitizer range was set to be from 0 to 2 V. Therefore, the maximum allowable output signal from the detector package is given by

\[ 2 \times \frac{\text{ADC Upper Limit}}{\text{Signal Conditioning Gain}} = 2 \times \frac{2}{-3} = -1.33 \text{ V} \]  

(4.7)

while the clipping op amp U7 lower limit was set to \(-1.5\) V. This was done to insure the linearity of the signal conditioning stage by avoiding the non-linear knee between the linear and clip regions in the op amp input-output characteristics.

A 10-MHz clock signal was externally applied to the ADC. Therefore, it continuously digitizes the analog signal during each clock cycle. The digitized data was buffered and stored in a certain memory location in a 16-bit, 16 k, dual-port RAM. The data storage location or address was set by a 13-bit counter formed by cascading three 4-bit binary counters and a JK flip flop. The counter and the RAM share the same 10-MHz
clock in order to synchronize them with the ADC. Connecting the most significant bit (MSB) of the left RAM address to the supply enables the counter only to access its upper half while the lower half of the RAM is kept for data averaging proposes. Thus, the maximum real time window for the digitized data can be obtained by

$$\text{Data Time Window} = \frac{\text{Storage Space}}{\text{Clock Frequency}} = \frac{16 \times 1024/2}{10 \times 10^6} = 819.2 \mu \text{sec}$$  \hspace{1cm} (4.8)$$

which is enough to record both the on and off line DIAL laser signal returns.

![Diagram of data collection and storage circuit](image)

Figure 4.6 Block diagram of the data collect and store circuit.

The counter operation is controlled by the microcontroller. At the beginning of the circuit operation, the microcontroller sends a clear signal to the counter resetting its output to the left address 2000H equivalent to the right address C000H which is the first storage location in the RAM, as shown in Figure 4.7. The ADC output will be continuously stored in this location until the trigger signal is received.
When the microcontroller senses the trigger signal, it sends a start count or "counter enable" signal to the counter causing it to address successive memory locations in the RAM in order to store the useful data. After scanning half the memory, when the counter reaches its maximum count of 1FFFH, which is equivalent to memory in the address of 3FFFH, an "end-of-count" signal will be sent back to the microcontroller indicating the end of the time window record. Therefore, the useful data will be available to the microcontroller in the address range from C000H to FFFFH, as shown in the memory map in Figure 4.7.69-73
The 16-MHz, 87C196KB-16 microcontroller is shown in the block diagram of Figure 4.8. The memory map of the microcontroller and the RAM is shown in Figure 4.7. The microcontroller address and data are shared on the same bus using address latching. The microcontroller address is decoded to access the right address of the RAM, a FIFO and a dip switch. The memory section, starting with the nibble 7, is reserved to access the FIFO as will be discussed in the output stage. While the memory section, starting with the nibble 6, was reserved for the control word, set by on-board 8-bit dip switches S1, the “not used” address range from 4000H to 5FFFH can be used for system upgrades to the 87C196KC microcontroller.74-78

After storing the ADC data in the RAM, the counter sends an “end-of-count” signal to the microcontroller. The microcontroller starts to transfer and add the data from the upper half of the RAM to its lower half for averaging. At the end of each averaging cycle, the data will be transferred to the FIFO which is waiting to transfer data to the reading device. The dip-switch output is buffered and was used to give the microcontroller a control word to indicate the averaging times required with a maximum of 4 averages. Also, it indicates the record length which could be 1, 2, 4 or 8 k words corresponding to 102.4, 204.8, 409.6 or 819.2 μs, respectively. (In case of record length less than 8k, the ADC data will still be stored in 8k and the first 4k, 2k or 1k will be considered and the rest of the data will be neglected.)62

One advantage of the selected microcontroller is its built-in 8 channel 10-bit ADC, two channels of which are reserved for the detector bias voltage and temperature monitor readings.75-76
Figure 4.8 Microcontroller connection block diagram.

Figure 4.9 shows the block diagram of the output stage of the digital circuit. The FIFO is formed by a parallel connection of two 8-k, 9-bit FIFO's memories to form an 18-bit word to handle the 16-bit data. The output data was buffered and applied to four 4-channel, TTL-compatible optical isolators. These isolators are used to isolate the circuit and the reading device grounds. Finally, the data was read using a SCXI connector. The FIFO write and reset operations are controlled by the microcontroller, while the FIFO read is controlled by the reading device. In order to check the correct sequence of data handling, the empty flags of both FIFOs are read by the microcontroller. Any unequal state of these flags indicates a FIFO failure or data crash.

After the microcontroller sends the complete data set to the FIFO, it sends a “FIFO ready” signal to the reading device to synchronize it with the system. Both the FIFO ready and FIFO read signals are also optically isolated by U37 which are opto-couplers with dual separate channels, once again to separate the grounds to minimize noise pick up.
Finally, the microcontroller controls the FIFO reset signal in order to reset the FIFO before the first writing operation.62

![Block diagram of the output stage.](image)

**Figure 4.9** Block diagram of the output stage.

### 4.2. Detection system settings

This detection system was built on one 312-gm, 15x9 cm² printed circuit board using surface-mount technology. This was very challenging because of the sensitivity of the different elements to the board layout, since analog signals were subjected to different noise pick-up sources from the high switching frequency digital signals. The board layout was carefully designed to separate the analog and digital circuits on the two board sides with ground isolation between them. The whole detection system is optically isolated from any external instrument such as the clock generator, trigger input and computer. The only electrical connection between the detection system and any external device will be through the power supplies that had proper filtering and isolating the power grounds from the circuit grounds. The calculated power consumption of the card is 21.1 W (see Appendix C).18-20,62
4.2.1. Microcontroller program

Figure 4.10 shows the flowchart of the microcontroller program. After switching on the power supplies, the start sequence begins by resetting the microcontroller chip and configuring its port, as shown in Figure 4.11. Port 1 is used for the counter and FIFO control and monitoring, while port 2 is used for sensing the trigger input and serial communication if used.74

The microcontroller then reads the control word from the dip switch for averaging and record length settings, as shown in Figure 4.12. Then, it starts an infinite loop by clearing the counter in order to address the first data storage location in the RAM (2000H as shown in Figure 4.7). The microcontroller then enters a waiting loop for the trigger input. This trigger comes from the lidar transmitting system. If the trigger signal is sensed, the microcontroller starts the counter in order to store the output digitized data from the ADC. During this time, the microcontroller waits for the “end-of-count” signal from the counter.

If the microcontroller sensed the end of count signal, indicating the storage of the useful data, it starts transferring the data. The amount of the transferred data is 1, 2, 4 or 8 k words depending on the record length setting. If averaging was not used, the data will be transferred directly to the FIFO, and the data ready signal will be transmitted to the reading device. The sequence will be repeated in the next cycle. If averaging was used, the data will be transferred to the averaging memory locations as indicated in Figure 4.7; then, the cycle will be repeated to acquire additional data to be added to the previous data. After completing the number of averages, the final averaged data will be sent to the FIFO, and a ready signal will be transmitted to the reading device and the sequence repeated.
Figure 4.10 Flowchart of the microcontroller program.

Figure 4.11 Microcontroller ports 1 and 2 configuration.
4.2.2. Data acquisition card

The final data stored in the FIFO is transferred to a personal computer using the PCI-DIO-32HS parallel input-output data acquisition card manufactured by National Instruments, Inc. The PCI-DIO-32HS is the state-of-the-art input-output data acquisition card which can be software configured using C++ language and can acquire data with up to a 20-MHz data transfer rate. The flowchart of the card program is shown in Figure 4.13 while the card connection to detection system is shown in Figure 4.14.

The card waits for the microcontroller data ready signal which is sensed by an acknowledge pin (ACK). If this signal is set, the card will start a pattern of data request signals (REQ) which will be used to read the FIFO using two parallel ports. This data set will be stored in a vector. Successive data sets will be added to this vector according to the number of the software averaging setting. The final averaged data is stored in an output file representing the DIAL detected signal.
Figure 4.13 Flowchart of the PCI-DIO-32HS data acquisition card.

Figure 4.14 PCI-DIO-32HS data acquisition card connection to the detection system.
The whole system operation is summarized in the data flow diagram of Figure 4.15. The limitations of the averaging time $T_A$, transfer to FIFO time, $T_F$, and the external transfer time, $T_E$, are given in Table 4.1.

![Figure 4.15 Detection system data flow diagram.](image)

### Table 4.1 Timing intervals for different record lengths.

<table>
<thead>
<tr>
<th>Record Length</th>
<th>$T_A$ (µs)</th>
<th>$T_F$ (ms)</th>
<th>$T_E$ (ms)</th>
<th>Laser Frequency (Hz (maximum))</th>
</tr>
</thead>
<tbody>
<tr>
<td>1 k word</td>
<td>102.4</td>
<td>10.3</td>
<td>0.6</td>
<td>90.1</td>
</tr>
<tr>
<td>2 k</td>
<td>204.8</td>
<td>20.5</td>
<td>1.2</td>
<td>45</td>
</tr>
<tr>
<td>4 k</td>
<td>409.6</td>
<td>41</td>
<td>2.5</td>
<td>22.5</td>
</tr>
<tr>
<td>8 k</td>
<td>819.2</td>
<td>82</td>
<td>4.9</td>
<td>11.3</td>
</tr>
</tbody>
</table>

### 4.3. Laboratory performance testing

The laboratory performance testing was performed on the individual circuits and for the whole system. The setup of the detection system performance testing is shown in Figure 4.16. The DIAL return signal was simulated using a 788-nm wavelength laser diode. A diffuser and neutral density filter (NDF) with variable settings were used to
condition the optical signal in terms of uniformity and intensity. The check point was used to either observe the analog circuit output or to inject an external signal to the digital circuit.

Figure 4.16 Experimental setup for detection system laboratory performance testing.

4.3.1. Temperature and bias voltage controllers performance

The APD temperature was set to 0.3 °C by setting R18 equal to zero. For an initial APD temperature of 23.6 °C, Figure 4.17 shows the transient response of the APD temperature monitor voltage $V_{TM}$, the thermistor resistance, the APD temperature and the TEC current. The rise time is approximately 5 s, and the 5-percent settling time is approximately 50 s with about 2 °C of overshoot. The steady-state temperature was 0.3±0.3 °C. The temperature measurement is obtained by converting the temperature monitor voltage to a thermistor resistance according to equation (4.5), and then this is
further converted into temperature according to equation (4.4). From Figure 4.17a and c, it is interesting to note a linear relationship between the APD temperature, $T$, and the temperature monitor voltage, $V_{TM}$ over a 30 °C operating range which is approximated by

$$T = 17.2 \cdot V_{TM} - 43.6.$$  

(4.9)

![Figure 4.17 APD temperature controller response](image)

(a) Temperature Monitor Output  
(b) Thermistor Variation  
(c) APD Temperature Variation  
(d) TEC Current

Figure 4.17 APD temperature controller response (a) temperature monitor, (b) thermistor resistance variation, (c) temperature variation and (d) TEC current.

Figure 4.17d shows a steady-state TEC current of approximately 0.35 A which corresponds to a steady state TEC input power of 174 mW. For successful temperature
controller operation, the maximum ambient temperature is 27 °C. Since the controller was designed to cool the detector, the minimum ambient temperature is theoretically equal to the controller temperature setting.\textsuperscript{53}

The APD voltage bias controller was set to produce a bias voltage of 336 V. This value was chosen to avoid breakdown at low operating temperature. Figure 4.18 shows the turn-on transients APD voltage bias monitor and its bias voltage obtained using equation (4.1). The measured steady state bias is 336.6±0.6 V with a settling time of 1.3 s and rise time of 75 ms with an undershoot of 297.4 V.

![Figure 4.18 APD voltage bias monitor and bias voltage transients.](image)

4.3.2. Signal conditioning circuit performance

In order to evaluate the signal conditioning stage gain, the APD output was replaced by a calibrated voltage input, and the output was then measured. Figure 4.19 shows the normalized gain versus the input voltage. The mean gain along the input range of the signal conditioning stage was measured to be 1.52 with 0.2 % standard deviation. The
clipping action of this stage is clear and starts at an input signal of 1.33 V corresponding to an output of 1.99 V which is compatible with the ADC. The frequency response of the signal conditioning stage is shown in Figure 4.20. This was measured by applying a known sinusoidal input and measuring the change in the amplitude and phase due to the change in the frequency. The input frequency was varied from 1 kHz to 3 MHz. The cutoff frequency at -3 dB is 2.4 MHz which is compatible with the digitization frequency of 10 MHz.

Figure 4.19 Signal conditioning stage normalized gain versus input voltage.

Figure 4.21 shows the APD and the signal conditioning stage noise spectrum obtained with no input (dark conditions) using a spectrum analyzer with 400 averages. This measurement suggested the use of batteries instead of power supplies to eliminate the power frequency harmonics noise pickup shown in the figure. The battery operation

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spectrum shows the 1/f noise with a knee at 3 kHz. Pickup noise at the fundamental power frequency is clear from the figure and can be eliminated by proper shielding in the final packaging. The average integrated noise was found to be 150 nV/Hz$^{1/2}$ in the operating frequency range which indicates that the APD noise contribution is the dominant source. Considering the 2.5 MHz system bandwidth and the APD responsivity, this corresponds to a minimum detectable signal level of $1.5 \times 10^{-3}$ W/m$^2$.

![Normalized Gain](image-a.png)

![Phase Shift](image-b.png)

Figure 4.20 Signal conditioning stage frequency response for the (a) gain and (b) phase shift.

4.3.3. Digitizer performance

Several operational tests were performed to check the operation of the digital circuit. These tests included the following:

- The microcontroller ability to access the dip-switch, RAM and FIFO.
• The counter ability to address the RAM.

• The interface card ability to read the FIFO.

In order to test the performance of the whole digitizer circuit, a histogram test was applied to check for any missing codes. In the histogram test, a sine-wave is applied to the digitizer input with a non-coherent frequency with the sampling rate of the digitizer. The amplitudes of this signal must be selected slightly out of the digitizer range to insure the coverage of all possible codes. Several samples of the input signal were taken and the occurrence of every possible ADC output is counted. The selected sine-wave for this test had a 4.95-kHz frequency with 2.03 V peak-to-peak and 997.3 mV offset levels, shown in Figure 4.22a. The over and under range data shown in the figure insures that the input signal covers the whole digitizer range; therefore, all codes must be present in the

Figure 4.21 APD and signal conditioning stage low frequency noise spectrum using (a) power supplies and (b) batteries.
histogram plot. The histogram plot is shown in Figure 4.22b for 500 cycles. The height of each point is proportional to the total number of times that code occurred. Missing codes would appear at zero height. Figure 4.22b indicates no missing codes.

![Graphs showing digitizer output and histogram plot](image)

Figure 4.22 (a) Input sine-wave signal to the digitizer and (b) the histogram plot which indicates no missing codes.

4.3.4. Overall system performance

Testing of the whole detection system was performed in order to characterize its gain and SNR. The input optical signal was obtained from a 788-nm laser diode corresponding to an APD responsivity of 117.5 A/W at a bias voltage of 336 V and 0.3 °C operating temperature. The laser diode current and temperature were kept constant using a driver circuit and a temperature controller to stabilize its operation. Single-shot pulsed signals with 100 μs duration and variable intensities were obtained to measure the gain and SNR. Neutral density filters were used for changing the laser input intensity. Using the setup shown in Figure 4.16, the experimental intensity level was varied between a
minimum of $8.5 \times 10^{-5}$ W/m$^2$ to a maximum of $8.42 \times 10^{-2}$ W/m$^2$ to insure the linearity of the system. Figure 4.23a shows the system output in counts versus the input light intensity which indicates a linear relation with a constant total gain of 183,960 counts/(W/m$^2$) over the characterized range. Figure 4.23b shows the SNR versus the input laser intensity. The SNR was obtained by squaring the ratio of the detected pulse mean value to its standard deviation. A minimum SNR of 2.7 was obtained in this experiment.

Figure 4.23 (a) System output in counts versus input light intensity obtained with no averaging at 788 nm and (b) the corresponding signal-to-noise ratio.

In order to determine the minimum measurement capabilities of the system, the lidar return signals were simulated in order to obtain the minimum water vapor detection capabilities of the system. To convert the lidar detected signals into a water vapor number density profile the DIAL equation is used which is given by

$$N(R) = \frac{1}{2 \cdot \Delta R \cdot \Delta \sigma} \ln \left[ \frac{P_{\text{OFF}}(R) \cdot P_{\text{ON}}(R)}{P_{\text{OFF}}(R_1) \cdot P_{\text{ON}}(R_1)} \right].$$

(4.10)
where $N$ is the water vapor number density, $\Delta R$ is the range cell, $\Delta \sigma$ is the differential absorption cross section and $P_{\text{ON}}$ and $P_{\text{OFF}}$ are the DIAL on-line and off-line return signals, respectively. Ideally, if the on-line and off-line return signals are identical, the water vapor number density should be zero, as indicated in the above equation.

Applying this concept to the detection system, one can estimate the minimum detectable water vapor number density, which is determined by the system noise as shown in Figure 4.24. Therefore, the laser diode was configured to give two identical exponential decaying pulses with a 30 $\mu$s time constant as shown in Figure 4.24a. The first pulse was to simulate the on-line return while the second pulse was to simulate the off-line pulse.

Figures 4.24b and c show the single shot water vapor number density obtained for the lower and upper troposphere, respectively, with no averaging. The DIAL calculations were performed using a range cell of 300 m and water vapor differential absorption cross section of $10 \times 10^{-24}$ cm$^2$ and $150 \times 10^{-24}$ cm$^2$ for the lower and upper troposphere, respectively, as specified by the LASE detection system. The DIAL calculation indicated a minimum detectable water vapor number density of $6.7 \times 10^{16}$ cm$^3$ for the lower troposphere and $4.5 \times 10^{15}$ cm$^3$ for the upper troposphere. These water vapor number densities are comparable to those for the LASE instrument which are $5 \times 10^{17}$ cm$^3$ and $5 \times 10^{14}$ cm$^3$ for lower and upper troposphere, respectively, with 1000 shot averages. This indicates the improved water vapor detection capabilities of the new system by a factor of 9 for the upper troposphere measurements.
Figure 4.24  (a) Simulated lidar return signals. (b) Water vapor number density noise floor for the lower troposphere and (c) for the upper troposphere.
CHAPTER V

THE LIDAR THEORY

In this chapter, the derivation of the backscattering lidar equation will be discussed. The modification of the equation to include the absorption and the geometry of the receiver system also will be given. Based on the backscattering-absorption lidar equation, the differential absorption lidar (DIAL) equation will be derived. Finally, application of the backscattering lidar equation for measuring aerosols will be discussed as well as the application of the DIAL equation for water vapor measurement.

5.1. The Lidar Equation

The scattering form of the lidar equation defines the received atmospheric backscattered laser power in terms of laser pulses propagated into the atmosphere and collected by the receiver that is located near the laser transmitter. The variation in the received intensity is used to determine the density profile of atmospheric molecules and aerosols as a function of the altitude.

Under the assumption of a pulsed lidar, the variation in the signal power $\Delta P(\lambda, R)$ received by the detection system in the wavelength range $(\lambda, \lambda + \Delta \lambda)$ from the range element $(R, R + \Delta R)$ is given by

$$\Delta P(\lambda, R) = \int J(\lambda, R, r) \cdot \Delta \lambda \cdot \Delta R \cdot p(\lambda, R, r) dA(R, r),$$

where $J(\lambda, R, r)$ is the laser-induced spectral radiance at wavelength $\lambda$, at position $r$ in the range $R$ per unit range interval, $p(\lambda, R, r)$ is the probability that radiation of wavelength $\lambda$
scattered from position r at range R will be detected and dA(R,r) is the element of the
target area at position r and range R.

The target spectral radiance J(λ,R,r) depends on the nature of the interaction
between the laser radiation and the target medium. For elastic or inelastic scattering
medium, J(λ,R,r) will be given by\textsuperscript{5}

\[ J(\lambda, R, r) = \beta(\lambda_L, \lambda, R, r) \cdot I(R, r), \] (5.2)

where I(R,r) is the laser intensity at position r and range R and \( \beta(\lambda_L, \lambda, R, r) \) is the volume
backscattering coefficient given by\textsuperscript{5}

\[ \beta(\lambda_L, \lambda, R, r) = \sum_i N_i(R, r) \cdot \left( \frac{d\sigma(\lambda_L)}{d\Omega} \right)_i \cdot S_i(\lambda), \] (5.3)

where \( N_i(R, r) \) is the number density of scatterer species i, \( \{d\sigma(\lambda_L)/d\Omega\} \) is the differential
scattering cross section under irradiation with laser radiation at wavelength \( \lambda_L \) and \( S_i(\lambda) \)
is the fraction of the scattered radiation that falls into the wavelength interval \( (\lambda, \lambda + \Delta\lambda) \).

The probability \( p(\lambda, R, r) \) will be affected by several factors which are included in the
equation\textsuperscript{5}

\[ p(\lambda, R, r) = \frac{A_o}{R^2} \cdot T(\lambda, R) \cdot \xi(\lambda) \cdot \xi(R, r), \] (5.4)

where \( A_o/R^2 \) is the acceptance solid angle of the receiver optics with \( A_o \) being the area of
the telescope mirror, \( T(\lambda, R) \) is the atmospheric transmission factor at wavelength \( \lambda \) over
the range \( R \), \( \xi(\lambda) \) is the spectral transmission factor of the receiver which includes the
effect of any spectral selecting elements such as filters and \( \xi(R, r) \) is the overlap factor or
the geometrical form factor defined as the probability of radiation from position r at the
range R being detected based on geometrical considerations. In this section, \( \xi(R, r) \) will be

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assumed dependent only on the overlap area between the transmitted laser beam and the receiver telescope field of view. In sections 5.1.1 and 5.1.2, this term will be discussed in detail in terms of the receiver optics.

To evaluate the total power of the return signal collected by the receiver at the instance t (where \( t = 2R/c \) represents the time interval between the propagation of the laser pulse to the range R and the returned radiation to reach the receiver), equation (5.1) must be integrated with respect to both the received wavelength and the range R. The range integral is to account for the radiation reaching the receiver from any position along the path of the laser pulse from which scattering occurs. The wavelength integral is to consider the total receiver spectral window \( \Delta \lambda_0 \) centered at \( \lambda \), which is usually defined by the optical filter. Therefore, equation (5.1) can be expressed in the form

\[
P(\lambda, t) = \frac{R = \frac{c}{2}}{P(\lambda, t)} = \frac{R = \frac{c}{2}}{J(\lambda, R, r) \cdot p(\lambda, R, r) \cdot dA(R, r).} \quad (5.5)
\]

Substituting equations (5.2) and (5.4) into equation (5.5) yields:

\[
P(\lambda, t) = A_0 \frac{R = \frac{c}{2}}{P(\lambda, t)} = \frac{R = \frac{c}{2}}{\int_0^R \int_{\Delta \lambda_0} \xi(\lambda) \cdot \beta(\lambda, R, r) \cdot T(\lambda, R) \cdot I(R, r) \cdot dA(R, r)} \quad (5.6)
\]

The assumption that the observed radiation from the scattering medium is as narrow as that of the laser radiation and that both are much smaller than the receiver spectral window \( \Delta \lambda_0 \), suggest that both \( \xi(\lambda) \) and \( \beta \) can be treated as delta functions. Furthermore, assuming that the scattering medium is homogenous over the overlap between the field of view and the laser beam results in equation (5.6) being written in the form:
\[ P(\lambda, t) = A_0 \xi(\lambda) \int_0^{R=ct/2} \beta(\lambda_L, \lambda, R) \cdot T(\lambda, R) \cdot \frac{dR}{R^2} \int \xi(R, r) \cdot I(R, r) \cdot dA(R, r). \] (5.7)

As mentioned above, the assumption that the probability \( \xi(R, r) \) is unity where the field of view of the receiver overlaps with the laser beam and zero elsewhere, and that the lateral distribution of the laser pulse is uniform over an area \( A_L(R) \) at the range \( R \), results in

\[ \int \xi(R, r) \cdot I(R, r) \cdot dA(R, r) = \xi(R) \cdot I(R) \cdot A_L(R). \] (5.8)

Equation (5.7) can be written as

\[ P(\lambda, t) = A_0 \xi(\lambda) \int_0^{R=ct/2} \beta(\lambda_L, \lambda, R) \cdot T(\lambda, R) \cdot \xi(R) \cdot I(R) \cdot A_L(R) \frac{dR}{R^2}. \] (5.9)

For simplicity, assume that the temporal shape of the laser pulse is a rectangle of the duration \( \tau_L \). Then, the limits of the range integration of equation (5.9) are \( c(t-\tau_L)/2 \) to \( ct/2 \). Furthermore, the range of interest is much larger than the pulse duration. Thus, the range dependent parameters can be treated as constants over the small interval of the range integration. Then, the total received power can be expressed by

\[ P(\lambda, t) = A_0 \xi(\lambda) \cdot \beta(\lambda_L, \lambda, R) \cdot T(\lambda, R) \cdot \xi(R) \cdot I(R) \cdot A_L(R) \frac{ct\tau_L/2}{R^2}. \] (5.10)

For a rectangular laser pulse of duration \( \tau_L \), the intensity is given by

\[ I(R) = \frac{E_L \cdot T(\lambda_L, R)}{\tau_L \cdot A_L(R)}, \] (5.11)

where \( E_L \) is the output energy of the laser pulse and \( T(\lambda_L, R) \) is the atmospheric transmission factor at the laser wavelength to range \( R \). From the Beer-Lambert law, the transmission factors in equations (5.10) and (5.11) are given by.
\[ T(\lambda_L, R) = \exp \left( -\int_0^R \kappa(\lambda_L, R) \text{d}R \right) \]  

(5.12)

and

\[ T(\lambda, R) = \exp \left( -\int_0^R \kappa(\lambda, R) \text{d}R \right), \]  

(5.13)

where \( \kappa(\lambda_L, R) \) and \( \kappa(\lambda, R) \) are the atmospheric attenuation coefficients at the laser and detected wavelengths, respectively. Combining equation (5.12) and (5.13) leads to the total atmospheric transmission factor

\[ T(R) = T(\lambda, R) \cdot T(\lambda_L, R) = \exp \left( -\int_0^R \{ \kappa(\lambda_L, R) + \kappa(\lambda, R) \} \text{d}R \right). \]  

(5.14)

The increment of radiation energy at wavelength \( \lambda \) received by the detector during the interval \((t, t+\tau_d)\), where \( \tau_d \) is the integration period for the detector, is given by

\[ E(\lambda, R) = \int_{\frac{2\pi}{c}}^{\frac{\tau_d + 2\pi}{c}} P(\lambda, t) \text{d}t. \]  

(5.15)

Combining equations (5.10), (5.11), (5.14) and (5.15) yields the scattered laser energy received within the detector's response time, \( \tau_d \):

\[ E(\lambda, R) = E_L \xi(\lambda) \cdot T(R) \cdot \xi(R) \frac{\Delta \beta}{R^2} \frac{\beta(\lambda_L, \lambda, R) \tau_d}{2}. \]  

(5.16)

This is known as the basic scattering lidar equation.

For more general laser pulse shape, the average radiation power is given by

\[ p_L = \frac{E_L}{\tau_L}, \]  

(5.17)

and equation (5.16) will be modified to
\[ P(\lambda, R) = P_l \frac{A_0}{R^2} \xi(\lambda) \cdot \xi(R) \cdot \beta(\lambda_0, \lambda, R) \frac{c}{2} \cdot \exp \left(-\frac{\kappa(R)}{2} R \right). \]  

(5.18)

where from equation (5.14)

\[ \kappa(R) = \kappa(\lambda_0, R) + \kappa(\lambda, R). \]  

(5.19)

In the case of elastic (Mie or Rayleigh) scattering, the detected wavelength will be equal to the laser wavelength and will be given by

\[ P(\lambda, R) = P_l \frac{A_0}{R^2} \xi(\lambda) \cdot \xi(R) \cdot \beta(\lambda_0, \lambda, R) \frac{c}{2} \cdot \exp \left(-2 \frac{\kappa(\lambda_0, R)}{2} R \right). \]  

(5.20)

Equation (5.18) is the scattering lidar equation, while equation (5.20) is a special case which is often used in the differential absorption lidar technique.

5.1.1. Receiver optics geometry

In the development of the scattering lidar equation the geometrical probability factor \( \xi(R, r) \) was assumed unity wherever the field of view of the receiver optics overlaps the laser beam and zero elsewhere. Also, the distribution of the laser intensity was assumed uniform across the target plane. These assumptions are practical for long range measurements. For short range measurements these factors must be considered.

A more general form of the laser intensity at the range \( R \) given in equation (5.11) is

\[ I(R, r, \psi) = \frac{P_l T(\lambda_0, R)}{\pi W^2(R)} F(R, r, \psi). \]  

(5.21)

where \( r \) is the radial displacement of the point of interest in the target plane from the telescope axis and \( \psi \) is the corresponding azimuth angle from a vertical plane passing through this axis. As shown in Figure 5.1, \( W(R) \) is the radius of the laser pulse in the
target plane, and \( F(R,r,\psi) \) is the distribution of the laser power over the target plane at the instant of interest. The Gaussian distribution is common in this case and therefore

\[
F(R,r,\psi) = \exp\left(-\frac{r^*}{W(R)}\right)^2, \tag{5.22}
\]

where

\[
r^* = \left(r^2 + d^2 - 2 \cdot r \cdot d \cdot \cos \psi \right)^{1/2} \tag{5.23}
\]

and \( d \) represent the separation of the laser beam and telescope axis. Assuming a TEM\(_{00}\) mode laser, the radius of the laser beam is given by

\[
W(R) = \left(W_0^2 + \theta^2 R^2 \right)^{1/2}, \tag{5.24}
\]

where \( W_0 \) is the laser output aperture radius and \( \theta \) is half of the laser divergence angle. Also, the radius of the field of view of the telescope at range \( R \) is given by

\[
r_f(R) = r_0 + \phi R, \tag{5.25}
\]

where \( r_0 \) is the effective radius of the telescope mirror and \( \phi \) is half of the field of view angle of the telescope.

![Figure 5.1 Geometry of the target plane at range R.](image)

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Substituting equation (5.21) in equation (5.7) will yield the total scattered laser power received by the detection system in the temporal duration $T_l$ and is given by

$$P(\lambda, t) = P_L \frac{\pi c_t L}{2} \xi(\lambda) \frac{R^2}{R^2} \beta(\lambda, \lambda, R) \frac{T(R)}{W^2(R)} \times \int_{R}^{2\pi} \int_{r=0}^{\pi} \xi(R, r, \psi) \cdot F(R, r, \psi) \cdot r \cdot drd\psi .$$

(5.26)

This equation can be further simplified considering that the range $R$ is much greater than the laser pulse length; therefore, the range dependent functions can be considered constants in the small integration period. Thus, equation (5.26) can be written as

$$P(\lambda, t) = P_L \frac{c_t L}{2} \xi(\lambda) \frac{R^2}{R^2} \beta(\lambda, \lambda, R) \frac{T(R)}{W^2(R)} \times \int_{r=0}^{2\pi} \int_{r=0}^{\pi} \xi(R, r, \psi) \cdot F(R, r, \psi) \cdot r \cdot drd\psi .$$

(5.27)

In this case, the telescope effective area can be defined as

$$A(R) = \frac{A_0}{\pi W^2(R)} \times \int_{r=0}^{2\pi} \int_{r=0}^{\pi} \xi(R, r, \psi) \cdot F(R, r, \psi) \cdot r \cdot drd\psi ,$$

(5.28)

where $A_0 = \pi r_0^2$. Therefore, the scattering lidar equation (5.18) can be re-written as

$$P(\lambda, R) = P_L \frac{A(R)}{R^2} \xi(\lambda) \frac{c_t L}{2} \beta(\lambda, \lambda, R) \exp \left( - \int_{0}^{R} k(R) dR \right)$$

(5.29)

in which $A(R)$ in equation (5.29) has replaced $A_0 \xi(R)$ in equation (5.18).

### 5.1.2. Geometrical form factor for simple overlap

Using equation (5.28), the definition of the geometrical form factor $\xi(R)$ is given by

$$\xi(R) = \frac{1}{\pi W^2(R)} \times \int_{r=0}^{2\pi} \int_{r=0}^{\pi} \xi(R, r, \psi) \cdot F(R, r, \psi) \cdot r \cdot drd\psi .$$

(5.30)
Assuming a uniform intensity distribution over the area of illumination at the range \( R \) and considering a biaxial receiver system in which the laser axis is separated from the telescope optical axis by a distance \( d \), the geometrical form factor can be taken as a simple overlap factor and can be written as

\[
\xi(R) = \frac{\Lambda[r_l(R), W(R), d(R)]}{\pi W^2(R)},
\]

where \( \Lambda \) is the area overlap function. The separation between the laser and telescope axes in the target plane is

\[
d = d_0 - R\delta,
\]

where \( d_0 \) is the separation at the lidar receiver and \( \delta \) is the inclination angle between the laser and the telescope axes.

The area overlap function assumes three cases as indicated in Figure 5.2. The first (a) in which the telescope field of view does not overlap with the laser, the second (b) in which there will be a partial overlap and the third (c) will be for full overlap. Therefore, \( \Lambda \) will be given by

\[
\Lambda = \begin{cases} 
0 & d > r_T + W \\
\frac{W^2\psi_w + r_r^2\psi_r - r_r d \sin \psi_r}{\pi r_r^2} & |r_T - W| < d < r_T + W, \\
\frac{r_r d \sin \psi_r}{|r_T - W|} & d < |r_T - W| 
\end{cases}
\]

where

\[
\psi_w = \cos^{-1}\left(\frac{d^2 + W^2 - r_r^2}{2Wd}\right)
\]

and

\[
\psi_r = \cos^{-1}\left(\frac{d^2 + r_r^2 - W^2}{2r_r d}\right)
\]
The situation of partial overlap is shown in Figure 5.3.

Figure 5.2 The three possible cases for telescope field of view and laser overlap functions, (a) no overlap (b) partial overlap and (c) total overlap.

Figure 5.3 Geometry of the biaxial lidar illustrating the condition of partial overlap.

Introducing non-dimensional parameters as

\[ z = \frac{R}{r_o}, \quad A = \frac{r_o}{W_o}, \quad D = \frac{d_o}{r_o}, \quad \rho(z, \phi) = \frac{r_T}{r_o} = 1 + z\phi, \quad s(z, \delta) = \frac{d}{r_o} = D - z\delta, \]
\[ \omega(z, \theta) = \frac{W}{W_0} = \left[ 1 + z^2 \theta^2 A^2 \right]^{1/2}, \quad \text{and} \quad y(z, \theta, \phi) = \frac{\sigma^2(z, \theta)}{\rho^2(z, \phi) A^2}, \]

the overlap factor \( \xi(R) \) can be expressed by\textsuperscript{584-85}

\[
\xi(R) = \left\{ \begin{array}{ll}
\frac{\psi_w(z)}{\pi} + \frac{1}{\pi y(z)} \left[ \psi_r(z) - \frac{s(z)}{\rho(z)} \sin \psi_r(z) \right] & d > r_T + W \\
\frac{\psi_r(z)}{r_T^2(R)/W^2} d < |r_T - W| < r_T + W, \\
0 & d < |r_T - W| 
\end{array} \right.
\] (5.36)

where

\[
\psi_w(z) = \cos^{-1} \left( \frac{s^2(z) + y(z) \rho^2(z) - \rho^2(z)}{2s(z) \rho(z) \sqrt{y(z)}} \right) 
\] (5.37)

and

\[
\psi_r(z) = \cos^{-1} \left( \frac{s^2(z) + \rho^2(z) - y(z) \rho^2(z)}{2s(z) \rho(z)} \right). 
\] (5.38)

\section*{5.2. The DIAL Equation}

Differential absorption lidar (DIAL) is a powerful technique to selectively measure the density of molecules in the atmosphere as a function of altitude. It involves using two laser pulses of slightly different wavelength. One is chosen to coincide with a strong absorption feature of the specific molecular of interest and is known as the on-line wavelength \( \lambda_{on} \). The other is tuned to the side of the absorption feature where there is no absorption and is known as the off-line wavelength \( \lambda_{off} \) as illustrated in Figure 5.4.

The derivation of the DIAL measuring technique starts by considering the scattering lidar equation (5.20) and modifying the total attenuation coefficient \( \kappa(\lambda, R) \) to

\[
\kappa(\lambda, R) = \kappa(\lambda, R) + N(R) \sigma(\lambda), 
\] (5.39)
where $\kappa'(\lambda, R)$ is the attenuation coefficient exclusive of the absorption contribution from the molecular of interest, $N(R)$ is the number density of the molecular species at range $R$ and $\sigma(\lambda)$ is the absorption cross section at wavelength $\lambda$. Therefore, applying the lidar equation (5.20) at both the on and off-line wavelength respectively, we get

\[
P(\lambda_{\text{on}}, R) = P_t \frac{A_0}{R^2} \xi(\lambda_{\text{on}}) \beta(\lambda_{\text{on}}, R) \frac{c T_l}{2} \exp \left( -2 \int_{0}^{R} \left[ \kappa(\lambda_{\text{on}}, R) + N(R) \sigma_{\text{on}}(\lambda_{\text{on}}) \right] dR \right)
\]

\[(5.40)\]

\[
P(\lambda_{\text{off}}, R) = P_t \frac{A_0}{R^2} \xi(\lambda_{\text{off}}) \beta(\lambda_{\text{off}}, R) \frac{c T_l}{2} \exp \left( -2 \int_{0}^{R} \left[ \kappa(\lambda_{\text{off}}, R) + N(R) \sigma_{\text{off}}(\lambda_{\text{off}}) \right] dR \right)
\]

\[(5.41)\]

Figure 5.4 DIAL on-line and off-line wavelengths relative to water vapor absorption line.

Then, the ratio of the return signals at the two wavelengths is obtained by dividing equation (5.40) by (5.41) to obtain
where the difference between the on and off-line wavelengths is less than 0.1 nm. Therefore, one can assume that the receiver spectral transmission factor is independent of wavelength over this small interval and similarly for the volume backscattering coefficients and atmospheric attenuation coefficients. Also, the output laser power is assumed equal for both wavelengths, and \( \Delta \sigma = \sigma_{\text{on}} - \sigma_{\text{off}} \) is the differential absorption cross section.

To evaluate the integration in equation (5.42), we use two successive ranges, \( R_1 \) and \( R_2 \) respectively, to obtain

\[
\frac{P(\lambda_{\text{on}}, R)}{P(\lambda_{\text{off}}, R)} = \exp \left( -2 \int_{0}^{R} N(R) \Delta \sigma dR \right),
\]

(5.43)

\[
\frac{P(\lambda_{\text{on}}, R_2)}{P(\lambda_{\text{off}}, R_2)} = \exp \left( -2 \int_{0}^{R_2} N(R) \Delta \sigma dR \right).
\]

(5.44)

Therefore,

\[
2 \Delta \sigma \int_{R_1}^{R_2} N(R) dR = \ln \left[ \frac{P(\lambda_{\text{on}}, R_1) P(\lambda_{\text{off}}, R_2)}{P(\lambda_{\text{off}}, R_1) P(\lambda_{\text{on}}, R_2)} \right].
\]

(5.45)

The number density function can be assumed constant in the small interval \( \Delta R = R_2 - R_1 \) which defines the range cell. Hence, we get

\[
N(R) = \frac{1}{2 \Delta \sigma \Delta R} \ln \left[ \frac{P(\lambda_{\text{on}}, R_1) P(\lambda_{\text{off}}, R_2)}{P(\lambda_{\text{off}}, R_1) P(\lambda_{\text{on}}, R_2)} \right].
\]

(5.46)

Equation (5.46) is known as the differential absorption lidar or DIAL equation, and it is used to obtain the number density of a specific molecular species as a function of range.
5.3. Applied Lidar Measurement Technique

In a typical lidar system, the return scattered radiation is collected by the receiver telescope and then applied to a detector using focusing optics in order to convert the optical signal into an electric one. Furthermore, the electric signal is digitized and stored in digital form in a storage device. The stored data is available in the form of digitizer counts versus number of samples, as shown in Figure 5.5. Knowing the digitization frequency $f_s$ and considering the speed of light in air, the sample intervals can be transformed into altitude or range using the range cell $R_c$ relation

$$R_c = \frac{c}{2f_s}.$$  \hfill (5.47)

![Figure 5.5 Ideal lidar return signal as obtained from the digitizer output.](image)

The roll-off from the peak count in the return signal defines the beginning of the useful data. The maximum altitude or range is obtained by considering the minimum count, which corresponds to the receiver system signal-to-noise ratio, after subtracting the signal background.
5.3.1. Aerosol measurement

To measure the aerosol density as a function of altitude, the visible and infrared laser beams are used. These wavelengths are not absorbed but scattered by the molecular and aerosols species; thus, we can use the backscattering lidar equation (5.20). The atmospheric volume backscattering coefficient has the form of

\[ \beta(\lambda, R) = \beta(R) = N(R) \frac{\sigma^4(\lambda)}{4\pi}. \]  

(5.48)

To obtain the aerosol profile (relative measurements) equation (5.20) can be simplified to

\[ P(R) = \text{(constant)} \cdot \frac{N(R)}{R^2} \cdot O_T, \]

(5.49)

where the geometrical probability factor \( \xi(R) \) is considered unity for full overlap and \( O_T \) is the optical thickness defined by the exponential term of equation (5.20) considering the atmospheric attenuation coefficients of scattering species. Comparing the aerosol profile to the standard atmospheric number density \( N_{\text{STD}}(R) \), results in the aerosol scattering ratio expressed by

\[ N(R) = N_{\text{STD}}(R) \cdot N_{\text{SR}}(R). \]

(5.50)

Considering the digitizer gain \( G_d \) expressed in counts/(W/m²), the digitizer counts, \( C_d \), can be converted to the return signal power and the aerosol scattering ratio can be obtained by

\[ N_{\text{SR}}(R) = \frac{1}{G_d \text{(constant)}} \cdot \frac{C_d(i)R^3}{O_T N_{\text{STD}}(R)}. \]

(5.51)

and

\[ R = i \cdot \frac{R_c}{2f_s}, \]

(5.52)
where $i$ is the sample number. To avoid the complexity of evaluating the constant term of equation (5.51), the scattering ratio is usually normalized to the standard atmospheric number density at a chosen altitude.

5.3.2. Water vapor measurement

Using the DIAL equation (5.46), the water vapor number density $N_{WV}(R)$ can be obtained from the digitizer data according to

$$N_{WV}(R) = \frac{1}{2 \Delta \sigma \Delta R} \cdot \frac{C_{\text{off}}(i+1) \cdot C_{\text{on}}(i)}{C_{\text{off}}(i) \cdot C_{\text{on}}(i+1)}$$

and

$$R = i \cdot \frac{R_c}{2f_s}.$$  

where $C_{\text{on}}$ and $C_{\text{off}}$ are the on- and off-line return signal in counts. In order to smooth the water vapor profile, averaging can be used for $M$ data points where

$$C'(i) = \frac{\sum_{j=1}^{M} C(j)}{M}.$$  

In this case, the range cell given in equation (5.47) will be modified to

$$R_c = \frac{c}{2f_s} M.$$
CHAPTER VI

VALIDATION OF THE DETECTION SYSTEM

The validation of the new water vapor detection system is discussed in this chapter. The new detection system was connected to a telescope with focusing optics and filter to construct a lidar receiver system. This receiver system was used to measure the atmospheric return signals for relative aerosol and absolute water vapor density measurements as a function of altitude. The aerosol measurement was obtained simultaneously with NASA Langley Research Center ozone and aerosol DIAL system. The water vapor measurement was obtained by using a telescope and a laser transmitter manufactured by Science and Engineering Services, Inc. (SESI). The measured water vapor profile was compared with profiles obtained from Dulls Airport and Wallops Island radiosondes.

6.1. Receiver system setup

The new water vapor DIAL detection system was attached to a telescope and focusing optics in order to build a lidar receiver system. The receiver is compatible with radiation in the visible for aerosol measurement and near infrared region for water vapor density measurements. A schematic diagram of this receiver system used for both aerosol and water vapor measurements is shown in Figure 6.1.

Both 30.5 cm and 35.6 cm diameter telescopes were used to collect backscattered radiation for aerosol and water vapor measurements respectively. These telescopes had a Newtonian design with parabolic mirrors to focus the radiation and a flat mirror to turn...
the focus on an optical fiber. A mechanism was used to allow the telescope to move in two-dimension plane to focus the backscattered signal. The optical fiber had a 1 mm silica core and a doped silica clad of 1.1-mm with a 0.28 numerical aperture. This optical fiber was custom designed by Cerme Optic, Inc. with an operating wavelength range of 200 to 1200 nm. The use of the optical fiber eliminates the need to align the focusing optics with the telescope for compact receiver systems.

![Image](image_url)

**Figure 6.1** Water vapor DIAL detection system as a part of the receiver.

The focusing optics consists of a plano-convex lens L1, a narrow-band interference filter F and another plano-convex lens L2, as indicated in Figure 6.1. The filter was changed according to the wavelength of the transmitted laser. The output beam is aligned with the APD sensitive area using a three-dimension translation-stages mechanism to move the detection system. Assuming a Gaussian beam distribution and considering the diffraction effect, the light spot diameter at the focus $d_A$ containing 84% of the total energy (Airy disk diameter) is defined by

$$d_A = 2.44 \frac{\lambda \cdot F}{D},$$

(6.1)
where \( F \) and \( D \) are the focal length and the diameter of the focusing lens \( L2 \). The focal spot diameter was checked for every operating conditions in order to insure that the APD sensitive area is not over-flown by the incoming light.

The alignment of the focusing optics with the APD sensitive surface was tested by simulating the lidar return using a stroboscope as a light source as shown in Figure 6.2. The telescope collects the reflected light signal from the ceiling and the focusing optics focuses the optical signal onto the APD. The trigger generator is used for synchronizing the detection system with the stroboscope optical signal. This was done by triggering both devices simultaneously with the delay unit used to adjust the collected signal in the digitizer time window. The alignment was obtained by moving the detection system in three-dimensions to give the optimum output signal from the detection system as shown in Figure 6.3.

Figure 6.2 Focusing optics alignment setup with the detection system.
6.2. Detection system validation with NASA airborne DIAL system

Simultaneous measurements of aerosol profiles were obtained using both the new detection system and the NASA Langley Research Center airborne DIAL system, as shown in Figure 6.4. The measurements were obtained during ground testing of the system carried out on October 7, 1999.

Figure 6.4 Detection system validation setup with NASA Langley Research Center airborne DIAL system.
The NASA DIAL system consists of a laser transmitter, a receiver with a telescope and a data acquisition system. The DIAL system measured aerosol backscattered profiles at 598-, 622- and 1064-nm wavelengths. The visible wavelengths were compatible with the new detection system and were used to validate it. The visible wavelengths were separated by 300 μs with pulse energies of about 50 mJ for both wavelengths and a pulse duration of 15 ns. The laser fire frequency was 30 Hz while the receiver digitization rate was 1 MHz.

The new detection system was synchronized with the NASA DIAL system through the laser precursor signal which defines the time duration between the two laser pulses. This signal was applied to a delay stage, the output of which was used to trigger the new detection system. This delay was applied in order to adjust the backscattered return signals with the digitizer time window. The measured return signals from the new DIAL detection system are shown in Figure 6.5a and b for the 589- and 622-nm wavelengths respectively. The signals were obtained using 24 shot averages with 5-MHz digitization frequency applied using a separate clock generator. The digitization frequency was reduced in order to extend the time window to 1.64 ms. The 622-nm return signal shown in Figure 6.5 indicates an over-load which resulted in clipping of the return signal. As a result of the clipping stage, this over-load did not affect the measurement. This was indicated in Figure 6.6a which shows the aerosol profiles obtained from both systems compared to the atmospheric standard molecular density. The large aerosol return at lower altitude is due to the atmosphere boundary layer. The disagreement between the measurements at lower altitude may be due to the telescope misalignment in the near field region. Figure 6.6b shows similar profiles obtained at the-598 nm wavelength. The
aerosol profiles of the new detection system where calculated by applying equations (5.51) and (5.52) using a 300 m range cell.

Figure 6.5 New detection system return signal obtained at (a) 598 nm and (b) 622 nm with 24 shot average and 5 MHz digitization frequency.

Figure 6.6 Aerosol profiles obtained from the NASA DIAL system and the new detection system at (a) 622 nm and (b) 598 nm compared to the atmospheric standard molecular density.
6.3. Water vapor DIAL detection system validation

Science and Engineering Services, Inc. of Burtonsville MD, has developed a compact diode-pumped Cr:LiSAF tunable laser to be used as the transmitter for water vapor DIAL measurements from robotic aircraft. This system operates at 816-nm wavelength with a maximum laser pulse energy of 25 mJ and a repetition rate of 5 Hz.

The new water vapor DIAL detection system was used with this transmitter. The optical fiber cable and the focusing optics were used in conjunction with a 30 cm diameter telescope to form a coaxial DIAL transmitter-receiver system. On November 5, 1999, this DIAL system was used to measure the atmospheric water vapor profile. The return signals for the on- and off-line are shown in Figure 6.7 for a 1000 shot average and 10-MHz digitization frequency. The on- and off-line wavelengths are 815.3251 and 815.3278, respectively, and the corresponding differential absorption cross-section is $5 \times 10^{-24} \text{ cm}^2$. The laser energy was about 20 mJ per pulse. The water vapor profile was compared to profiles obtained from radiosonde data from both Dulles Airport near Washington, D.C., and NASA Wallops, Wallops Island VA, as given in tables 6.1 and 6.2 respectively. Figure 6.8 shows the water vapor profiles from the radiosondes and the DIAL system obtained using a 600 m range cell. The water vapor mass mixing ratio, $r$, obtained from the radiosonde data where converted to number density, $n$, according to the relation

$$n = \frac{N_A \cdot r \cdot \rho_s}{M}, \quad (6.2)$$

where $N_A$ is Avogadro's number, $M$ is the molecular weight of water which is equal to 18 kg/kmole and $\rho_s$ is the air density. According to the ideal gas law, since the air density is
a function of both temperature and pressure, its value was obtained as a function of altitude referring to the standard atmospheric data of the United States at zero altitude, where the air pressure, temperature and density are $1.01325 \times 10^3$ mBar, 288.15 K and 1.225 kg/m$^3$ respectively.\textsuperscript{87}

Figure 6.7 On and off-line return signals.

Figure 6.8 Water vapor profiles obtained from the new system and radiosondes.

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Table 6.1 Dulles Airport water vapor profile data on November 5, 1999 at 12:00 pm.

<table>
<thead>
<tr>
<th>Altitude M</th>
<th>Temperature °C</th>
<th>Pressure mBar</th>
<th>Density kg/m^3</th>
<th>Water Vapor gm/kg</th>
<th>Water Vapor cm^3</th>
</tr>
</thead>
<tbody>
<tr>
<td>82</td>
<td>-2.3</td>
<td>1020</td>
<td>1.31193</td>
<td>2.89</td>
<td>1.3x10^{17}</td>
</tr>
<tr>
<td>242</td>
<td>9.2</td>
<td>1000</td>
<td>1.23382</td>
<td>1.55</td>
<td>6.4x10^{16}</td>
</tr>
<tr>
<td>309</td>
<td>13.8</td>
<td>992</td>
<td>1.20432</td>
<td>1.39</td>
<td>5.6x10^{16}</td>
</tr>
<tr>
<td>893</td>
<td>9.2</td>
<td>925</td>
<td>1.14128</td>
<td>1.31</td>
<td>5.0x10^{16}</td>
</tr>
<tr>
<td>1587</td>
<td>4.0</td>
<td>850</td>
<td>1.06842</td>
<td>1.00</td>
<td>3.6x10^{16}</td>
</tr>
</tbody>
</table>

Table 6.2 Wallops Island water vapor profile data on November 5, 1999 at 12:00 pm.

<table>
<thead>
<tr>
<th>Altitude M</th>
<th>Temperature °C</th>
<th>Pressure mBar</th>
<th>Density kg/m^3</th>
<th>Water Vapor gm/kg</th>
<th>Water Vapor cm^3</th>
</tr>
</thead>
<tbody>
<tr>
<td>16</td>
<td>8.6</td>
<td>1030</td>
<td>1.2735</td>
<td>4.81</td>
<td>2.0x10^{17}</td>
</tr>
<tr>
<td>80</td>
<td>9.8</td>
<td>1022</td>
<td>1.2483</td>
<td>4.58</td>
<td>1.9x10^{16}</td>
</tr>
<tr>
<td>195</td>
<td>13.8</td>
<td>1008</td>
<td>1.2237</td>
<td>2.38</td>
<td>9.7x10^{16}</td>
</tr>
<tr>
<td>262</td>
<td>13.4</td>
<td>1000</td>
<td>1.2157</td>
<td>2.33</td>
<td>9.5x10^{16}</td>
</tr>
<tr>
<td>664</td>
<td>11.0</td>
<td>953</td>
<td>1.1684</td>
<td>1.47</td>
<td>5.7x10^{16}</td>
</tr>
<tr>
<td>911</td>
<td>9.2</td>
<td>925</td>
<td>1.1413</td>
<td>1.20</td>
<td>4.6x10^{16}</td>
</tr>
<tr>
<td>1606</td>
<td>4.0</td>
<td>850</td>
<td>1.06842</td>
<td>0.71</td>
<td>2.5x10^{16}</td>
</tr>
</tbody>
</table>

Figure 6.8 indicates a good agreement between the DIAL system and the radiosonde systems specially in the near-field. The deviation in the far-field might be due to the difference in measurement location and time. Therefore, the expected return signal had to be calculated using the lidar equation.

The measured return signals were compared to the expected return signal, calculated from the lidar equation (5.16). Both signals are shown in Figure 6.9. To obtain this profile, the geometrical form factor was considered for total overlap condition and was calculated using equation (5.36). The transmitted laser beam had a 2-mm diameter with 10^{-3} radian divergence angle and 3x10^{-3} radian telescope field of view. The total atmospheric transmission factor was calculated considering the optical thickness and the standard atmospheric number density given in equations (5.49) and (5.50) respectively.
Good agreement between the measured and calculated profiles, as shown in Figure 6.9, indicates the validity of the new DIAL detection system.

Figure 6.9 Measured and calculated return signals.
CHAPTER VII

CONCLUSIONS

In this dissertation, an advanced water vapor DIAL detection system was designed, constructed and evaluated. The system consists of an advanced APD detector, an analog circuit and a digital circuit all on one, small size low mass, printed circuit board. The system was interfaced to a personal computer. Both atmospheric aerosol and water vapor concentration profiles were measured using this system.

The optical detector is a critical device in this system. A drift diffusion model was developed for the APD to better understanding the device operation. This model is suitable to solve for the device transient and steady-state operation assuming a four-layer structure such as the reach-through and SLIK APD structures. An equivalent circuit was also presented in order to model these devices in circuit simulation packages.

The APD choice was based on characterizing a group of such devices with different structures from different manufactures. The characterization results indicate the better performance of the SLIK structure over the reach-through structure in terms of noise and device stability with respect to temperature. The selected advanced APD package had the advantages of a built-in TEC and thermistor for temperature control and built-in trans-impedance amplifier for direct current to voltage conversion.

The new detection system consists of an analog circuit and a digital circuit. The analog circuit was designed using state-of-the-art electronics and controlled the APD in terms of operating temperature and bias voltage. Also, it consists of a signal conditioning stage, which adjusted the APD output to be compatible with the digitizer circuit.
The digital circuit consists of a digitizer, microcontroller and output circuit. The digitizer was constructed using a state-of-the-art 14-bit, 10-MHz ADC, a dual port RAM and a 13-bit counter to address the storage locations of the ADC output. The microcontroller was used to synchronize the detection system with the laser fire pulse. Also, it can perform real time averaging of the recorded data and monitor the APD operating bias voltage and temperature. The output stage consists of a FIFO which is used to collect the digital data and transfer it to a personal computer for storage.

The system design assumes an external power supply, clock and trigger signals. The whole system was integrated onto one small printed circuit board suitable to be mounted directly on the lidar receiver telescope. The final digital data is read using a parallel input-output interface with up to a 20 MHz data transfer rate. The operation of this interface is completely controllable using software. The final data is stored in an ASCII file which is accessible with any data handling software. The summary of the detection system performance parameters is given in table 7.1.

The detection system validation started by reviewing the theory of the lidar remote sensing technique with a special focus on the DIAL measuring technique. The transformation from raw data representing the detection system output into a meaningful atmospheric water vapor profile was also discussed. The integration of the detection system into a complete receiver, using focusing optics and a telescope allowed the validation of the system experimentally. One validation experiment was obtained by measuring relative aerosol profiles simultaneously with the NASA Langley Research Center airborne aerosol and ozone DIAL system. The other validation experiment was obtained by integrating the new receiver system with a laser transmitter manufactured by
Science and Engineering Services Inc., and measuring water vapor profile which were compared to Dulles Airport and Wallops Island water vapor radiosonde results. Both experiments demonstrated the capability of the system in terms of range and measuring atmospheric species other than water vapor.

Table 7.1 DIAL detection system performance summary.

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Value</th>
</tr>
</thead>
<tbody>
<tr>
<td>End-to-end gain</td>
<td>183,969 counts/(W/m²)</td>
</tr>
<tr>
<td>Maximum output</td>
<td>16383 counts</td>
</tr>
<tr>
<td>Minimum detectable signal @ 820 nm</td>
<td>0.85 μW/m²</td>
</tr>
<tr>
<td>Maximum detectable signal @ 820 nm</td>
<td>0.84 mW/m²</td>
</tr>
<tr>
<td>Dynamic range</td>
<td>1000</td>
</tr>
<tr>
<td>Maximum digitization frequency</td>
<td>10 MHz</td>
</tr>
<tr>
<td>Maximum time window</td>
<td>819.2 μs</td>
</tr>
<tr>
<td>Maximum repetition rate (8 k word)</td>
<td>10 Hz</td>
</tr>
<tr>
<td>Total Noise Equivalent Power (NEP)</td>
<td>212 fW/Hz¹/²</td>
</tr>
<tr>
<td>Power consumption</td>
<td>21.1 W</td>
</tr>
<tr>
<td>Card size</td>
<td>15x9 cm²</td>
</tr>
<tr>
<td>Card weight</td>
<td>312 gm</td>
</tr>
<tr>
<td>Power supplies</td>
<td>± 5 V and ± 12 V</td>
</tr>
<tr>
<td>APD Sensitive area</td>
<td>0.238 mm²</td>
</tr>
</tbody>
</table>

Although the system performance is acceptable, future research is required for additional improvements. One such improvement would be to replace the current ADC with a 16-bit, 20-MHz ADC. The availability of fast computer interfaces suggests omitting the microcontroller, which would result in even a more compact system. Also, more effort is needed in developing the SLIK structure APDs with larger sensitive areas.

The good performance of the system suggested its application in aircraft based water vapor DIAL systems such as the LASE instrument and space based DIAL systems such as the visible channel of the Ozone Research with Advanced Cooperative Lidar Experiment (ORACLE).
REFERENCES


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APPENDIX A

APD MANUFACTURER DATA
AND CHARACTERIZATION RESULTS

A.1. APD designator and manufacturer data

<table>
<thead>
<tr>
<th>APD</th>
<th>Manufacturer</th>
<th>Structure</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td>Model Number</td>
<td>d&lt;sup&gt;2&lt;/sup&gt;</td>
</tr>
<tr>
<td></td>
<td>Serial Number</td>
<td>T&lt;sup&gt;7&lt;/sup&gt;</td>
</tr>
<tr>
<td>APD12</td>
<td>EG&amp;G SLIK</td>
<td></td>
</tr>
<tr>
<td>C30649E</td>
<td>0.5</td>
<td>50 MV/W</td>
</tr>
<tr>
<td>147</td>
<td>25</td>
<td>820</td>
</tr>
<tr>
<td>APD11</td>
<td>EG&amp;G SLIK</td>
<td></td>
</tr>
<tr>
<td>C30649E</td>
<td>0.5</td>
<td>50 MV/W</td>
</tr>
<tr>
<td>148</td>
<td>25</td>
<td>820</td>
</tr>
<tr>
<td>APD10</td>
<td>Electron Tubes, Inc. RTS</td>
<td></td>
</tr>
<tr>
<td>SSO-AD-2500</td>
<td>2.52</td>
<td>45 A/W</td>
</tr>
<tr>
<td>#8-12</td>
<td>21.5</td>
<td>880</td>
</tr>
<tr>
<td>APD9</td>
<td>Electron Tubes, Inc. RTS</td>
<td></td>
</tr>
<tr>
<td>SSO-ADH-500</td>
<td>0.5</td>
<td>45 A/W</td>
</tr>
<tr>
<td>#10</td>
<td>21.5</td>
<td>880</td>
</tr>
<tr>
<td>APD8</td>
<td>EG&amp;G RTS</td>
<td></td>
</tr>
<tr>
<td>C30646E</td>
<td>0.5</td>
<td>20 MV/W</td>
</tr>
<tr>
<td>CD2507</td>
<td>22</td>
<td>850</td>
</tr>
<tr>
<td>APD7</td>
<td>EG&amp;G RTS</td>
<td></td>
</tr>
<tr>
<td>C30646E</td>
<td>1.5</td>
<td>6 MV/W</td>
</tr>
<tr>
<td>CD2508</td>
<td>22</td>
<td>1064</td>
</tr>
</tbody>
</table>

1 "SLIK" for super low k structure, "RTS" for reach through structure and "BE" for beveled edge structure.
2 Diameter of the sensitive area in mm.
3 APD responsivity.
4 Bias Voltage in V.
5 Spectral noise current and voltage density in nA/Hz<sup>1/2</sup> and nV/Hz<sup>1/2</sup> respectively.
6 Bandwidth in MHz.
7 Testing temperature in °C.
8 Testing wavelength in nm.
9 Breakdown voltage in V.
10 Dark current in nA.
11 Noise equivalent power in pW/Hz<sup>1/2</sup>.
### A.2. SLIK APD package

- **Detector Sensitive Area**: 0.24 mm² (measured)
- **Trans-Impedance Amplifier Feedback Resistance**: 560 kΩ
- **Detector Maximum Power Loss**: 50 MW
- **TEC Maximum Current**: 1.8 A
- **TEC Rated Current @ 0 °C**: 0.5 A
- **TEC Area**: 3.96 x 3.96 mm²
- **Thermistor Resistance**

\[
R_T = 10^4 \cdot e^{-\left(\frac{3940}{T - 256}\right)}
\]
A.3. APD calibration results

Responsivity at 720 nm is 38.3 A/W
820 nm is 39.8 A/W
940 nm is 23.4 A/W

Responsivity at 720 nm is 45.6 A/W
820 nm is 50.1 A/W
940 nm is 30.7 A/W

Responsivity at 720 nm is 37.1 A/W
820 nm is 39.8 A/W
940 nm is 21.3 A/W

Responsivity at 720 nm is 23.2 A/W
820 nm is 25.1 A/W
940 nm is 13.2 A/W

Responsivity at 720 nm is 7.8 MV/W
820 nm is 8.4 MV/W
940 nm is 5.2 MV/W

Responsivity at 720 nm is 17.6 MV/W
820 nm is 23.5 MV/W
940 nm is 29.1 MV/W

Fig. 8 APD spectral response calibration.

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Fig. 8 (continue) APDs spectral response calibration.

### A.4. APD surface scan results

<table>
<thead>
<tr>
<th>APD</th>
<th>Active Area (mm$^2$)</th>
<th>Area non-uniformity</th>
</tr>
</thead>
<tbody>
<tr>
<td>APD11</td>
<td>0.2376</td>
<td>14.96 %</td>
</tr>
<tr>
<td>APD10</td>
<td>4.9550</td>
<td>18.76 %</td>
</tr>
<tr>
<td>APD9</td>
<td>0.1800</td>
<td>11.27 %</td>
</tr>
<tr>
<td>APD8</td>
<td>0.1820</td>
<td>16.62 %</td>
</tr>
<tr>
<td>APD7</td>
<td>1.5970</td>
<td>15.50 %</td>
</tr>
<tr>
<td>APD6</td>
<td>0.0148</td>
<td>17.64 %</td>
</tr>
<tr>
<td>APD5</td>
<td>18.88</td>
<td>7.40 %</td>
</tr>
<tr>
<td>APD4</td>
<td>0.5464</td>
<td>6.02 %</td>
</tr>
<tr>
<td>APD2</td>
<td>1.6920</td>
<td>6.10 %</td>
</tr>
</tbody>
</table>

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A.5. APD responsivity variation with temperature

<table>
<thead>
<tr>
<th>APD</th>
<th>Bias Voltage</th>
<th>Condition</th>
<th>720 nm</th>
<th>820 nm</th>
<th>940 nm</th>
</tr>
</thead>
<tbody>
<tr>
<td>APD12</td>
<td>336 V</td>
<td>-3 &lt; T &lt; 25 °C</td>
<td>116.3 - 8.69T + 0.43T² - 8.3 × 10⁻³T³</td>
<td>A/W</td>
<td>113.8 - 8.23T + 0.41T² - 7.9 × 10⁻³T³</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>720 nm</td>
<td>820 nm</td>
<td>940 nm</td>
</tr>
<tr>
<td>APD11</td>
<td>415 V</td>
<td>-3 &lt; T &lt; 25 °C</td>
<td>130.02 - 9.63T + 0.45T² - 8.3 × 10⁻³T³</td>
<td>A/W</td>
<td>136.19 - 9.85T + 0.46T² - 8.6 × 10⁻³T³</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>720 nm</td>
<td>820 nm</td>
<td>940 nm</td>
</tr>
<tr>
<td>APD10</td>
<td>110 V</td>
<td>5 &lt; T &lt; 23 °C</td>
<td>3.85 × 10⁻³ - 9.65 × 10⁻²T + 90.53T² - 3.71T³ + 0.0557T⁴</td>
<td>A/W</td>
<td>4.22 × 10⁻³ - 10.62 × 10⁻²T + 99.88T² - 4.09T³ + 0.0617T⁴</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>720 nm</td>
<td>820 nm</td>
<td>940 nm</td>
</tr>
<tr>
<td>APD9</td>
<td>150 V</td>
<td>10.4 &lt; T &lt; 21.9 °C</td>
<td>58.9 - 2.92T + 8.82 × 10⁻²T² - 1.33 × 10⁻³T³</td>
<td>A/W</td>
<td>66.8 - 3.53T + 9.96 × 10⁻²T² - 1.15 × 10⁻³T³</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>720 nm</td>
<td>820 nm</td>
<td>940 nm</td>
</tr>
<tr>
<td>APD8</td>
<td>190 V</td>
<td>5 &lt; T &lt; 23 °C</td>
<td>1.5 × 10⁻⁷ - 4.9 × 10⁻⁵T + 7.6 × 10⁻³T²</td>
<td>V/W</td>
<td>1.6 × 10⁻⁷ - 4.9 × 10⁻⁵T + 7.58 × 10⁻³T²</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>720 nm</td>
<td>820 nm</td>
<td>940 nm</td>
</tr>
<tr>
<td>APD7</td>
<td>380 V</td>
<td>13.3 &lt; T &lt; 24.5 °C</td>
<td>2.24 × 10⁻⁶ - 3.26 × 10⁻⁵T + 1.63 × 10⁻⁴T² - 2.77 × 10⁻⁶T³</td>
<td>V/W</td>
<td>3.06 × 10⁻⁶ - 4.46 × 10⁻⁵T + 2.24 × 10⁻⁴T² - 3.79 × 10⁻⁶T³</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>720 nm</td>
<td>820 nm</td>
<td>940 nm</td>
</tr>
<tr>
<td>APD6</td>
<td>410 V</td>
<td>1.1 &lt; T &lt; 21.9 °C</td>
<td>2.91 × 10⁻⁶ - 4.63 × 10⁻⁵T + 3.07 × 10⁻⁴T² - 6.8 × 10⁻⁶T³</td>
<td>V/W</td>
<td>2.81 × 10⁻⁶ - 4.53 × 10⁻⁵T + 3.04 × 10⁻⁴T² - 6.79 × 10⁻⁶T³</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>720 nm</td>
<td>820 nm</td>
<td>940 nm</td>
</tr>
<tr>
<td>APD2</td>
<td>317 V</td>
<td>5.7 &lt; T &lt; 23.1 °C</td>
<td>928.5 - 189.9T + 17.1T² - 0.6985T³ + 0.011T⁴</td>
<td>A/W</td>
<td>1043.2 - 192.3T + 15.8T² - 0.6005T³ + 0.0086T⁴</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>720 nm</td>
<td>820 nm</td>
<td>940 nm</td>
</tr>
</tbody>
</table>
### A.6. APD responsivity variation with bias voltage

<table>
<thead>
<tr>
<th>APD12</th>
<th>Temperature : 25 °C</th>
<th>Condition : 320 &lt; V&lt; 351 V</th>
</tr>
</thead>
<tbody>
<tr>
<td>720 nm</td>
<td>1.88x10^-7 - 2.25x10^-5 V + 1x10^-3 V^2 - 2.02x10^-3 V^3 + 2x10^-5 V^4</td>
<td>AW</td>
</tr>
<tr>
<td>820 nm</td>
<td>1.89x10^-7 - 2.27x10^-5 V + 1x10^-3 V^2 - 2.04x10^-3 V^3 + 1.5x10^-5 V^4</td>
<td>AW</td>
</tr>
<tr>
<td>940 nm</td>
<td>1.01x10^-7 - 1.22x10^-5 V + 5.47x10^-3 V^2 - 1.09x10^-3 V^3 + 8.2x10^-4 V^4</td>
<td>AW</td>
</tr>
</tbody>
</table>

<table>
<thead>
<tr>
<th>APD11</th>
<th>Temperature : 23 °C</th>
<th>Condition : 390 &lt; V&lt; 430 V</th>
</tr>
</thead>
<tbody>
<tr>
<td>720 nm</td>
<td>-2.76x10^-5 + 2.06x10^-3 V - 5.12x10^-3 V^2 + 4.25x10^-3 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>820 nm</td>
<td>-2.91x10^-5 + 2.17x10^-3 V - 5.41x10^-3 V^2 + 4.49x10^-3 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>940 nm</td>
<td>-1.65x10^-5 + 1.23x10^-3 V - 3.07x10^-3 V^2 + 2.54x10^-3 V^3</td>
<td>AW</td>
</tr>
</tbody>
</table>

<table>
<thead>
<tr>
<th>APD10</th>
<th>Temperature : 20.9 °C</th>
<th>Condition : 80 &lt; V&lt; 115 V</th>
</tr>
</thead>
<tbody>
<tr>
<td>720 nm</td>
<td>-9.1x10^-3 + 296.7 V - 3.19x10^-1 V^2 + 1.14x10^-1 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>820 nm</td>
<td>-9.5x10^-3 + 308.6 V - 3.32x10^-1 V^2 + 1.19x10^-1 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>940 nm</td>
<td>-5.2x10^-3 + 167.7 V - 1.81x10^-1 V^2 + 6.46x10^-2 V^3</td>
<td>AW</td>
</tr>
</tbody>
</table>

<table>
<thead>
<tr>
<th>APD9</th>
<th>Temperature : 22 °C</th>
<th>Condition : 125 &lt; V&lt; 150 V</th>
</tr>
</thead>
<tbody>
<tr>
<td>720 nm</td>
<td>-3.2x10^-1 + 73.4 V - 0.55x10^-1 V^2 + 1.4x10^-1 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>820 nm</td>
<td>-3.6x10^-1 + 80.5 V - 0.61x10^-1 V^2 + 1.5x10^-1 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>940 nm</td>
<td>-1.9x10^-1 + 42.6 V - 0.32x10^-1 V^2 + 8x10^-2 V^3</td>
<td>AW</td>
</tr>
</tbody>
</table>

<table>
<thead>
<tr>
<th>APD8</th>
<th>Temperature : 19.9 °C</th>
<th>Condition : 100 &lt; V&lt; 215 V</th>
</tr>
</thead>
<tbody>
<tr>
<td>720 nm</td>
<td>-2.1x10^-1 + 3.98x10^-1 V - 2.5x10^-2 V^2 + 5x10^-3 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>820 nm</td>
<td>-2.25x10^-1 + 4.2x10^-1 V - 2.6x10^-2 V^2 + 5.35x10^-3 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>940 nm</td>
<td>-1.4x10^-1 + 2.69x10^-1 V - 1.66x10^-2 V^2 + 3.4x10^-3 V^3</td>
<td>AW</td>
</tr>
</tbody>
</table>

<table>
<thead>
<tr>
<th>APD7</th>
<th>Temperature : 22.1 °C</th>
<th>Condition : 100 &lt; V&lt; 380 V</th>
</tr>
</thead>
<tbody>
<tr>
<td>720 nm</td>
<td>3.81x10^-1 - 9.19x10^-6 V + 7.83x10^-2 V^2 - 27.1 V^3 + 3.33x10^-2 V^4</td>
<td>AW</td>
</tr>
<tr>
<td>820 nm</td>
<td>5.07x10^-1 - 1.22x10^-5 V + 1.04x10^-5 V^2 - 36.1 V^3 + 4.45x10^-5 V^4</td>
<td>AW</td>
</tr>
<tr>
<td>940 nm</td>
<td>6.28x10^-1 - 1.52x10^-5 V + 1.29x10^-5 V^2 - 44.7 V^3 + 5.52x10^-5 V^4</td>
<td>AW</td>
</tr>
</tbody>
</table>

<table>
<thead>
<tr>
<th>APD6</th>
<th>Temperature : 22.6 °C</th>
<th>Condition : 100 &lt; V&lt; 350 V</th>
</tr>
</thead>
<tbody>
<tr>
<td>720 nm</td>
<td>4.02x10^-1 - 8.77x10^-5 V + 6.8x10^-1 V^2 - 222.5 V^3 + 0.263 V^4</td>
<td>AW</td>
</tr>
<tr>
<td>820 nm</td>
<td>4.61x10^-1 - 10.02x10^-5 V + 7.75x10^-1 V^2 - 253.2 V^3 + 0.299 V^4</td>
<td>AW</td>
</tr>
<tr>
<td>940 nm</td>
<td>2.96x10^-1 - 6.35x10^-5 V + 4.89x10^-1 V^2 - 159.4 V^3 + 0.188 V^4</td>
<td>AW</td>
</tr>
</tbody>
</table>

<table>
<thead>
<tr>
<th>APD5</th>
<th>Temperature : 20 °C</th>
<th>Condition : 2050 &lt; V&lt; 2350 V</th>
</tr>
</thead>
<tbody>
<tr>
<td>720 nm</td>
<td>-1.73x10^-4 + 24.54 V - 0.012 V^2 + 0.184x10^-5 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>820 nm</td>
<td>-1.75x10^-4 + 24.79 V - 0.012 V^2 + 0.186x10^-5 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>940 nm</td>
<td>-0.94x10^-4 + 13.25 V - 0.006 V^2 + 0.099x10^-5 V^3</td>
<td>AW</td>
</tr>
</tbody>
</table>

<table>
<thead>
<tr>
<th>APD2</th>
<th>Temperature : 23.1 °C</th>
<th>Condition : 310 &lt; V&lt; 340 V</th>
</tr>
</thead>
<tbody>
<tr>
<td>720 nm</td>
<td>-1.71x10^-4 + 1.68x10^-3 V - 0.551 V^2 + 6.05x10^-4 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>820 nm</td>
<td>-3.28x10^-4 + 3.16x10^-3 V - 1.018 V^2 + 1.095x10^-3 V^3</td>
<td>AW</td>
</tr>
<tr>
<td>940 nm</td>
<td>-4.44x10^-4 + 4.25x10^-3 V - 1.36 V^2 + 1.45x10^-3 V^3</td>
<td>AW</td>
</tr>
</tbody>
</table>
### A.7. APD noise measurement

<table>
<thead>
<tr>
<th>APD</th>
<th>λ nm</th>
<th>$I_a$</th>
<th>NEP [fW/Hz$^{1/2}$]</th>
<th>$D^*$ [cmHz$^{1/2}$/W]</th>
</tr>
</thead>
<tbody>
<tr>
<td>APD12</td>
<td>720</td>
<td>2.2x10^{-13} A/Hz$^{1/2}$</td>
<td>1.9</td>
<td>2.87x10$^{13}$</td>
</tr>
<tr>
<td></td>
<td>820</td>
<td></td>
<td>1.9</td>
<td>3.05x10$^{13}$</td>
</tr>
<tr>
<td></td>
<td>940</td>
<td></td>
<td>3.9</td>
<td>1.63x10$^{13}$</td>
</tr>
<tr>
<td>APD11</td>
<td>720</td>
<td>2.3x10^{-13} A/Hz$^{1/2}$</td>
<td>1.8</td>
<td>2.77x10$^{13}$</td>
</tr>
<tr>
<td></td>
<td>820</td>
<td></td>
<td>1.7</td>
<td>2.90x10$^{13}$</td>
</tr>
<tr>
<td></td>
<td>940</td>
<td></td>
<td>3.1</td>
<td>1.57x10$^{13}$</td>
</tr>
<tr>
<td>APD10</td>
<td>720</td>
<td>2.5x10^{-12} A/Hz$^{1/2}$</td>
<td>74.3</td>
<td>2.99x10$^{12}$</td>
</tr>
<tr>
<td></td>
<td>820</td>
<td></td>
<td>69.3</td>
<td>3.21x10$^{12}$</td>
</tr>
<tr>
<td></td>
<td>940</td>
<td></td>
<td>129.4</td>
<td>1.72x10$^{12}$</td>
</tr>
<tr>
<td>APD9</td>
<td>720</td>
<td>1.9x10^{-12} A/Hz$^{1/2}$</td>
<td>80.7</td>
<td>5.26x10$^{11}$</td>
</tr>
<tr>
<td></td>
<td>820</td>
<td></td>
<td>74.9</td>
<td>5.67x10$^{11}$</td>
</tr>
<tr>
<td></td>
<td>940</td>
<td></td>
<td>141.8</td>
<td>2.99x10$^{11}$</td>
</tr>
<tr>
<td>APD8</td>
<td>720</td>
<td>9.3x10^{-8} V/Hz$^{1/2}$</td>
<td>11.8</td>
<td>3.62x10$^{12}$</td>
</tr>
<tr>
<td></td>
<td>820</td>
<td></td>
<td>11.0</td>
<td>3.88x10$^{12}$</td>
</tr>
<tr>
<td></td>
<td>940</td>
<td></td>
<td>17.7</td>
<td>2.41x10$^{12}$</td>
</tr>
<tr>
<td>APD2</td>
<td>720</td>
<td>1.7x10^{-12} A/Hz$^{1/2}$</td>
<td>28.0</td>
<td>4.75x10$^{12}$</td>
</tr>
<tr>
<td></td>
<td>820</td>
<td></td>
<td>22.2</td>
<td>5.99x10$^{12}$</td>
</tr>
<tr>
<td></td>
<td>940</td>
<td></td>
<td>19.4</td>
<td>6.84x10$^{12}$</td>
</tr>
</tbody>
</table>
APPENDIX B

DETECTION SYSTEM APPLIED CIRCUITS

B.1. Analog-to-digital converter circuit

The AD9240 is a 10-M sample per second, 14-bit ADC. It has an on-chip low noise sample and hold amplifier and a programmable voltage reference. Figure B1 shows the associated programming circuit in our application. C32, C33, C34, C35 and Ca35 are 0.1-μF bypass capacitors between each supply and its corresponding ground pin. The AD9240 maximum conversion rate can be controlled by R34. VINA and VINB are two analog inputs for either a differential input mode or single-ended mode. By connecting VINB to VREF and SENSE via R33, the second mode is selected with a common mode at 1 V with 2 V input range. The chip internal reference, which appears on CAPT and CAPB, is used in this connection. C28, C29, C30 and C31 form the recommended decoupling network to insure a stable reference. It should be noted that this device provides the only connection between the analog and the digital grounds.

![Figure B1 Analog to digital converter circuit.](image)

B.2. Data collect and store circuit

The data collect and store circuit acts as a single shot transient recorder. The operation of this circuit is fully controlled by the microcontroller through the “counter enable” signal, applied by the two input NAND gate U15A. A microcontroller “clear counter” signal clears the contents of all three, four bit binary counters and the J-K flip flop. The maximum count is detected by four input NAND gate, U14A, which

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automatically stops the counting operation through U15A and sends an “end-of-count” signal to the microcontroller.

To reduce pick-up noise, the inverter U20A enables the data conversion by the ADC in a different half cycle than that of the counter. Connecting the MSB of the RAM left address to supply enable the data to be stored only in the lower half of the memory.

Figure B2 Data collect and store circuit.

B.3. Microcontroller connection circuit

The 80C196KB-16 microcontroller shares the data and address on one 16 bit bus. The address latch, formed by U24 and U25, is used to distinguish and separate the address and the data words. The inverter U20B is used to divide the microcontroller memory into two sections. One section accesses the right address of the dual port RAM, while the other section is sub-divided into two sub-sections. The two sub-sections are decoded to access the FIFO using the four input AND gate U26A, while the other is used to access the 8-bit dip-switch using the four input AND gate U26B and the inverters U20C and U20D. The control of the FIFO and counter operations is obtained using the microcontroller port 1. Port 2 is used to sense the “trigger” signal and for serial communication if applied. Port 0 is set as analog channels to the internal analog to digital
converter in order to read the APD temperature and bias voltage values. Each monitor channel is protected using the interface circuit shown in figure B4a. Figure B4b shows the microcontroller reset circuit.

Figure B3 Microcontroller connection circuit.
B.4. Output stage

The FIFO output data is buffered using U29 and U30, the output of which is applied to the four channel opto-couplers U31-U34 for ground optical isolation. The FIFO control signals “FIFO ready” and “read FIFO” are also optically isolated using the dual separate channels U37 optocouplers.

Figure B5 Microcontroller connection circuit.
B.5. Chip power supply bypassing

Generally, bypass or coupling capacitors are used with every supply pin of any device. It is used to supply the device with inrush current required at switching instants. Figure B6 shows the used power supply bypassing for an op amp, for both the positive and the negative supplies. Inductors Lx1 and Lx2 are used for smoothing the device bias current. As a layout restriction, ceramic capacitors (Cx3 and Cx1 are 0.1 μF) must be located less than 0.3 cm away from the supply pin. Cx2 and Cx4 are 10 μF electrolyte capacitors. For all devices other than op amps, 0.1 μF capacitors are only in use to couple every supply pin to the ground.

![Figure B6 Op amp connection to power supplies.](image)

B.6. Clock and trigger isolation

U38, the HCPL-2430, is a dual channel, TTL compatible optocoupler. It is used to optically isolate the clock and the trigger inputs as shown in Fig.D5. Resistors R41 and R42 are 50Ω termination resistors. R40 and R43 are used to limit light emitting diode current.

![Figure B7 External clock and trigger isolation circuit.](image)

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APPENDIX C

ELEMENTS OF THE NEW DETECTION SYSTEM

C.1. Detection system components

Referring to Chapter 4 and Appendix B, this appendix gives the component list of the new detection system along with the description of these component, the manufacturer and the number of parts used.

<table>
<thead>
<tr>
<th>Component</th>
<th>Part Reference</th>
<th>Description</th>
<th>Manufacturer</th>
<th># of Parts</th>
</tr>
</thead>
<tbody>
<tr>
<td>AD586BR</td>
<td>U1</td>
<td>Reference Voltage</td>
<td>Analog Devices</td>
<td>1</td>
</tr>
<tr>
<td>AD706AR</td>
<td>U2, U3, U5</td>
<td>Dual Op-Amp</td>
<td>Analog Devices</td>
<td>3</td>
</tr>
<tr>
<td>521-5-M</td>
<td>U4</td>
<td>High Voltage Supply</td>
<td>Analog Modules</td>
<td>1</td>
</tr>
<tr>
<td>C30649E</td>
<td>U6</td>
<td>Avalanche Photodiode</td>
<td>EG&amp;G</td>
<td>1</td>
</tr>
<tr>
<td>AD8036AR</td>
<td>U7</td>
<td>Clipping Amplifier</td>
<td>Analog Devices</td>
<td>1</td>
</tr>
<tr>
<td>AD8041AR</td>
<td>U8</td>
<td>Buffer Amplifier</td>
<td>Analog Devices</td>
<td>1</td>
</tr>
<tr>
<td>B3LL31-25-P/P</td>
<td>U9</td>
<td>Output Filter</td>
<td>Microwave Inc.</td>
<td>1</td>
</tr>
<tr>
<td>74F191SC</td>
<td>U10, U11, U12</td>
<td>4 Bit Counter</td>
<td>FAIRCHILD</td>
<td>3</td>
</tr>
<tr>
<td>TC74AC112FN</td>
<td>U13</td>
<td>Dual JK Flip Flop</td>
<td>TOSHIBA</td>
<td>1</td>
</tr>
<tr>
<td>TC74VHC20FT</td>
<td>U14</td>
<td>Dual, 4 input NAND</td>
<td>TOSHIBA</td>
<td>1</td>
</tr>
<tr>
<td>TC74VHC21FT</td>
<td>U26</td>
<td>Dual, 4 Input AND</td>
<td>TOSHIBA</td>
<td>1</td>
</tr>
<tr>
<td>TC74VHCT00AFT</td>
<td>U15</td>
<td>Quad.2 Input NAND</td>
<td>TOSHIBA</td>
<td>1</td>
</tr>
<tr>
<td>AD9240AS</td>
<td>U16</td>
<td>14 Bit, 10 MHz ADC</td>
<td>Analog Devices</td>
<td>1</td>
</tr>
<tr>
<td>TC74VHCT541AFT</td>
<td>U17, U18, U29, U30</td>
<td>Octal Buffers</td>
<td>TOSHIBA</td>
<td>4</td>
</tr>
<tr>
<td>IDT7026L20J</td>
<td>U19</td>
<td>Dual Port RAM</td>
<td>IDT</td>
<td>1</td>
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<tr>
<td>TC74VHC04FT</td>
<td>U20</td>
<td>Hex Inverters</td>
<td>TOSHIBA</td>
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<tr>
<td>TC74VHC573FT</td>
<td>U21, U22, U24</td>
<td>8 Bit, Address Latch</td>
<td>TOSHIBA</td>
<td>3</td>
</tr>
<tr>
<td>N87C196KB-16</td>
<td>U23</td>
<td>Microcontroller</td>
<td>INTEL</td>
<td>1</td>
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<tr>
<td>IDT7205L15J</td>
<td>U27, U28</td>
<td>8k, 9Bit, FIFO</td>
<td>IDT</td>
<td>2</td>
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<tr>
<td>HCPL-6650</td>
<td>U31, U32, U33, U34</td>
<td>4 Channel Optocoupler</td>
<td>Hewlett Packard</td>
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<tr>
<td>HCPL-6630</td>
<td>U37</td>
<td>2 Channel Optocoupler</td>
<td>Hewlett Packard</td>
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<tr>
<td>HCPL-2430#300</td>
<td>U38</td>
<td>2 Channel Optocoupler</td>
<td>Hewlett Packard</td>
<td>1</td>
</tr>
<tr>
<td>766-163-R(1k)</td>
<td>U25</td>
<td>1k, 2%, 160mW, Resistor Network</td>
<td>CTS</td>
<td>1</td>
</tr>
<tr>
<td>766-163-R(270)</td>
<td>U35, U36</td>
<td>270, 2%, 160mW, Resistor Network</td>
<td>CTS</td>
<td>2</td>
</tr>
<tr>
<td>LL4148DICT</td>
<td>D1, D3, D4, D5, D6</td>
<td>Diode, 1N4148</td>
<td>VISHAY</td>
<td>6</td>
</tr>
<tr>
<td>BZX84C5VDICT</td>
<td>D2</td>
<td>5.1V, Zener Diode</td>
<td>VISHAY</td>
<td>1</td>
</tr>
<tr>
<td>TIP110</td>
<td>Q1</td>
<td>Darlington Transistor</td>
<td>Texas Instrument</td>
<td>1</td>
</tr>
<tr>
<td>NFM46P1C15S</td>
<td>L1, L2, L4, L5, L16</td>
<td>Line Filter</td>
<td>MURATA</td>
<td>5</td>
</tr>
<tr>
<td>BLM41A151S</td>
<td>L3, L6, L7, L8, L9, L10, L11, L12, L13, L14, L15</td>
<td>Chip Ferrite Bead Inductors</td>
<td>MURATA</td>
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<tr>
<td>Component Part Reference</td>
<td>Description</td>
<td>Manufacturer</td>
<td># of Parts</td>
<td></td>
</tr>
<tr>
<td>---------------------------</td>
<td>-------------</td>
<td>--------------</td>
<td>-----------</td>
<td></td>
</tr>
<tr>
<td>1812Y104JXE C8</td>
<td>0.1 μF, 500 V, 5% Ceramic Capacitor</td>
<td>VISHAY</td>
<td>1</td>
<td></td>
</tr>
<tr>
<td>VJ1812Y105JXXM C2,C10,C5,C5a</td>
<td>1 μF, 25V, 5% Ceramic Capacitor</td>
<td>VISHAY</td>
<td>4</td>
<td></td>
</tr>
<tr>
<td>PCC472BCT C39,C40</td>
<td>5nF, 50V, 10%, Ceramic Capacitor</td>
<td>Panasonic</td>
<td>2</td>
<td></td>
</tr>
<tr>
<td>PCS1226CT C38</td>
<td>22μF, 6.3V Tantalum Capacitor</td>
<td>Panasonic</td>
<td>1</td>
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</tr>
<tr>
<td>PCC200CCT C36,C37</td>
<td>20pF, 50V, 5% Ceramic Capacitor</td>
<td>Panasonic</td>
<td>2</td>
<td></td>
</tr>
<tr>
<td>PCC220JCT C9</td>
<td>22pF, 3kV, 5% Ceramic Capacitor</td>
<td>Panasonic</td>
<td>1</td>
<td></td>
</tr>
<tr>
<td>PCS3106CT C14,C17,C21,C23,C25,C29,C3u23</td>
<td>10μF, 16V Tantalum Capacitor</td>
<td>Panasonic</td>
<td>6</td>
<td></td>
</tr>
<tr>
<td>PCC103BCT Cu31,Cu32,Cu33,CU34,C1u37,C2u37,C1u19,C2u19,C3u19,C1u23</td>
<td>0.01μF, 50V, 10% Coupling Capacitor</td>
<td>Panasonic</td>
<td>6</td>
<td></td>
</tr>
<tr>
<td>PCC104BCT C1,C3,C4,C6,C7,C11,C12,C13,C15,C16,C18,C19,C20,C22,C24,C26,C27,C28,C30,C31,C32,C33,C34,C35,Cu10,Cu35,Cu11,Cu12,Cu13,Cu14,Cu15,Cu17,Cu18,Cu20,Cu21,Cu22,Cu24,Cu26,Cu27,Cu28</td>
<td>0.1 μF, 50V, 10% Coupling Capacitor</td>
<td>Panasonic</td>
<td>42</td>
<td></td>
</tr>
<tr>
<td>895-0205 R32</td>
<td>5 Ω, 1% Resistor</td>
<td>Dale</td>
<td>2</td>
<td></td>
</tr>
<tr>
<td>P33ECT R33,Ra33</td>
<td>33Ω, 5% Resistor</td>
<td>Panasonic</td>
<td>2</td>
<td></td>
</tr>
<tr>
<td>P50FCT R21,R30,R31,R41,R42</td>
<td>49.9 Ω, 1% Resistor</td>
<td>Panasonic</td>
<td>5</td>
<td></td>
</tr>
<tr>
<td>TNPW1206100B R26</td>
<td>100 Ω, 1% Resistor</td>
<td>VISHAY</td>
<td>2</td>
<td></td>
</tr>
<tr>
<td>P130FCT R22</td>
<td>130 Ω, 1% Resistor</td>
<td>Panasonic</td>
<td>1</td>
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</tr>
<tr>
<td>P140FCT R23</td>
<td>140 Ω, 1% Resistor</td>
<td>Panasonic</td>
<td>1</td>
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</tr>
<tr>
<td>P270ECT R35,R36,R44,R45</td>
<td>270 Ω, 5% Resistor</td>
<td>Panasonic</td>
<td>4</td>
<td></td>
</tr>
<tr>
<td>TNPW1206301B R27,R28,R29</td>
<td>301 Ω, 1% Resistor</td>
<td>VISHAY</td>
<td>3</td>
<td></td>
</tr>
<tr>
<td>P499FCT R6</td>
<td>499 Ω, 1% Resistor</td>
<td>Panasonic</td>
<td>1</td>
<td></td>
</tr>
<tr>
<td>P620ECT R40,R43</td>
<td>620Ω, 5% Resistor</td>
<td>Panasonic</td>
<td>2</td>
<td></td>
</tr>
<tr>
<td>P2KZCT R14,R34</td>
<td>2 kΩ, 0.1% Resistor</td>
<td>Panasonic</td>
<td>2</td>
<td></td>
</tr>
<tr>
<td>P3KZCT R2</td>
<td>3 kΩ, 0.1% Resistor</td>
<td>Panasonic</td>
<td>1</td>
<td></td>
</tr>
<tr>
<td>P10KZCT R1,R8,R24,R25</td>
<td>10 kΩ, 0.1% Resistor</td>
<td>Panasonic</td>
<td>4</td>
<td></td>
</tr>
<tr>
<td>P22KZCT R13</td>
<td>22 kΩ, 0.1% Resistor</td>
<td>Panasonic</td>
<td>1</td>
<td></td>
</tr>
<tr>
<td>P33KZCT R17,R15,R16,R37</td>
<td>33 kΩ, 0.1% Resistor</td>
<td>Panasonic</td>
<td>4</td>
<td></td>
</tr>
<tr>
<td>P49.9KFCT R3</td>
<td>49.9 kΩ, 1% Resistor</td>
<td>Panasonic</td>
<td>1</td>
<td></td>
</tr>
<tr>
<td>P82KZCT R12</td>
<td>82 kΩ, 0.1% Resistor</td>
<td>Panasonic</td>
<td>1</td>
<td></td>
</tr>
<tr>
<td>P200KFCT R4,R5,R19</td>
<td>200 kΩ, 1% Resistor</td>
<td>Panasonic</td>
<td>3</td>
<td></td>
</tr>
</tbody>
</table>

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### Component List

<table>
<thead>
<tr>
<th>Component</th>
<th>Part Reference</th>
<th>Description</th>
<th>Manufacturer</th>
<th># of Parts</th>
</tr>
</thead>
<tbody>
<tr>
<td>R9,R10,R11</td>
<td>2.55 MΩ Resistor</td>
<td>3</td>
<td></td>
<td></td>
</tr>
<tr>
<td>R18,R38,R39</td>
<td>TBD</td>
<td></td>
<td></td>
<td></td>
</tr>
<tr>
<td>SM4W103</td>
<td>R7,R20</td>
<td>10 kΩ, POT, 10%</td>
<td>Philips</td>
<td>2</td>
</tr>
<tr>
<td>777600-01</td>
<td>J1</td>
<td>68 Pin Connector</td>
<td>AMP</td>
<td>1</td>
</tr>
<tr>
<td>AFR09G</td>
<td>J2</td>
<td>9 Pin D Connector</td>
<td>AMP</td>
<td>1</td>
</tr>
<tr>
<td>AMR09G</td>
<td>J3</td>
<td>9 Pin D Connector</td>
<td>AMP</td>
<td>1</td>
</tr>
<tr>
<td>CT2198MST</td>
<td>S1</td>
<td>8 Pin, Dip Switches</td>
<td>CTS</td>
<td>1</td>
</tr>
<tr>
<td>P8087SCT</td>
<td>S2</td>
<td>Push Button Switch</td>
<td>Panasonic</td>
<td>1</td>
</tr>
<tr>
<td>XC550CT</td>
<td>Y1</td>
<td>16 MHz Crystal</td>
<td>ECS</td>
<td>1</td>
</tr>
<tr>
<td>SK-PLCC68-S01</td>
<td>68 pin, PLCC Socket</td>
<td>Ironwood Elec.</td>
<td>1</td>
<td></td>
</tr>
</tbody>
</table>

### C.2. Detection system power consumption

The steady state maximum power consumption of the individual components of the detection system and the total power for each section are given as follows:

#### Reference Voltage

<p>| | | |</p>
<table>
<thead>
<tr>
<th></th>
<th></th>
<th></th>
</tr>
</thead>
<tbody>
<tr>
<td>P U1</td>
<td>500.00 mW</td>
<td></td>
</tr>
<tr>
<td>P U2</td>
<td>650.00 mW</td>
<td></td>
</tr>
<tr>
<td>P R1</td>
<td>2.50 mW</td>
<td></td>
</tr>
<tr>
<td>P R2</td>
<td>0.75 mW</td>
<td></td>
</tr>
</tbody>
</table>

**Total power P1** = 1153.25 mW (1)

#### Signal Conditioning

<p>| | | |</p>
<table>
<thead>
<tr>
<th></th>
<th></th>
<th></th>
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</thead>
<tbody>
<tr>
<td>P U6</td>
<td>250.00 mW</td>
<td></td>
</tr>
<tr>
<td>P U7</td>
<td>900.00 mW</td>
<td></td>
</tr>
<tr>
<td>P U8</td>
<td>900.00 mW</td>
<td></td>
</tr>
<tr>
<td>P R21</td>
<td>45.00 mW</td>
<td></td>
</tr>
<tr>
<td>P R24</td>
<td>0.70 mW</td>
<td></td>
</tr>
<tr>
<td>P R25</td>
<td>0.70 mW</td>
<td></td>
</tr>
<tr>
<td>P R26</td>
<td>22.50 mW</td>
<td></td>
</tr>
<tr>
<td>P R27</td>
<td>67.50 mW</td>
<td></td>
</tr>
<tr>
<td>P R28</td>
<td>67.50 mW</td>
<td></td>
</tr>
<tr>
<td>P R29</td>
<td>67.50 mW</td>
<td></td>
</tr>
<tr>
<td>P R30</td>
<td>101.30 mW</td>
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</tr>
<tr>
<td>P R31</td>
<td>101.30 mW</td>
<td></td>
</tr>
</tbody>
</table>

**Total power P2** = 2524.00 mW (2)

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### Voltage Controller

<table>
<thead>
<tr>
<th>Part</th>
<th>Power (mW)</th>
</tr>
</thead>
<tbody>
<tr>
<td>PU3</td>
<td>650.00</td>
</tr>
<tr>
<td>PU4</td>
<td>480.00</td>
</tr>
<tr>
<td>PR3</td>
<td>0.50</td>
</tr>
<tr>
<td>PR4</td>
<td>2.00</td>
</tr>
<tr>
<td>PR5</td>
<td>2.00</td>
</tr>
<tr>
<td>PR6</td>
<td>50.00</td>
</tr>
<tr>
<td>PR7</td>
<td>2.50</td>
</tr>
<tr>
<td>PR8</td>
<td>0.10</td>
</tr>
<tr>
<td>PR9-11</td>
<td>20.70</td>
</tr>
<tr>
<td>PR12</td>
<td>0.20</td>
</tr>
<tr>
<td>PR13</td>
<td>0.10</td>
</tr>
</tbody>
</table>

Total power: P3 = 1208.10 mW (3)

### Temperature Controller

<table>
<thead>
<tr>
<th>Part</th>
<th>Power (mW)</th>
</tr>
</thead>
<tbody>
<tr>
<td>PU5</td>
<td>650.00</td>
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<tr>
<td>PR14</td>
<td>24.50</td>
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<td>PD2</td>
<td>16.70</td>
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<tr>
<td>PR15</td>
<td>0.40</td>
</tr>
<tr>
<td>PR16</td>
<td>0.40</td>
</tr>
<tr>
<td>PR17</td>
<td>0.40</td>
</tr>
<tr>
<td>PR19</td>
<td>0.20</td>
</tr>
<tr>
<td>PR20</td>
<td>14.40</td>
</tr>
<tr>
<td>PRT</td>
<td>0.40</td>
</tr>
</tbody>
</table>

Total power: P4 = 707.40 mW (4)

### Data Collect and Store

<table>
<thead>
<tr>
<th>Part</th>
<th>Power (mW)</th>
</tr>
</thead>
<tbody>
<tr>
<td>PU10</td>
<td>100.00</td>
</tr>
<tr>
<td>PU11</td>
<td>100.00</td>
</tr>
<tr>
<td>PU12</td>
<td>100.00</td>
</tr>
<tr>
<td>PU13</td>
<td>180.00</td>
</tr>
<tr>
<td>PU14</td>
<td>180.00</td>
</tr>
<tr>
<td>PU15</td>
<td>180.00</td>
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<tr>
<td>PU16</td>
<td>285.00</td>
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<tr>
<td>PU17</td>
<td>180.00</td>
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<tr>
<td>PU18</td>
<td>180.00</td>
</tr>
</tbody>
</table>

Total power: P5 = 2625.00 mW (5)

### Microcontroller Circuit

<table>
<thead>
<tr>
<th>Part</th>
<th>Power (mW)</th>
</tr>
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<tbody>
<tr>
<td>PU19</td>
<td>750.00</td>
</tr>
<tr>
<td>PU20</td>
<td>180.00</td>
</tr>
<tr>
<td>PU21</td>
<td>180.00</td>
</tr>
<tr>
<td>PU22</td>
<td>180.00</td>
</tr>
<tr>
<td>PU23</td>
<td>1500.00</td>
</tr>
</tbody>
</table>

Total power: P6 = 1485.00 mW (6)
<p>| | | |</p>
<table>
<thead>
<tr>
<th></th>
<th></th>
<th></th>
</tr>
</thead>
<tbody>
<tr>
<td>PU24</td>
<td>180.00 mW</td>
<td></td>
</tr>
<tr>
<td>PU25</td>
<td>181.80 mW</td>
<td></td>
</tr>
<tr>
<td>PU26</td>
<td>180.00 mW</td>
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</tr>
<tr>
<td><strong>Total power</strong></td>
<td><strong>P7</strong></td>
<td><strong>3331.80 mW</strong></td>
</tr>
<tr>
<td><strong>Output Stage</strong></td>
<td></td>
<td></td>
</tr>
<tr>
<td>PU27</td>
<td>770.00 mW</td>
<td></td>
</tr>
<tr>
<td>PU28</td>
<td>770.00 mW</td>
<td></td>
</tr>
<tr>
<td>PU29</td>
<td>180.00 mW</td>
<td></td>
</tr>
<tr>
<td>PU30</td>
<td>180.00 mW</td>
<td></td>
</tr>
<tr>
<td>PU31</td>
<td>800.00 mW</td>
<td></td>
</tr>
<tr>
<td>PU32</td>
<td>800.00 mW</td>
<td></td>
</tr>
<tr>
<td>PU33</td>
<td>800.00 mW</td>
<td></td>
</tr>
<tr>
<td>PU34</td>
<td>800.00 mW</td>
<td></td>
</tr>
<tr>
<td>PU35</td>
<td>800.00 mW</td>
<td></td>
</tr>
<tr>
<td>PU36</td>
<td>800.00 mW</td>
<td></td>
</tr>
<tr>
<td>PU37</td>
<td>400.00 mW</td>
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<tr>
<td>PU38</td>
<td>700.00 mW</td>
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<tr>
<td>PR40</td>
<td>10.00 mW</td>
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</tr>
<tr>
<td>PR41</td>
<td>125.00 mW</td>
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</tr>
<tr>
<td>PR42</td>
<td>125.00 mW</td>
<td></td>
</tr>
<tr>
<td>PR43</td>
<td>10.00 mW</td>
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</tr>
<tr>
<td><strong>Total power</strong></td>
<td><strong>P8</strong></td>
<td><strong>8070.00 mW</strong></td>
</tr>
</tbody>
</table>

**Total Power for Analog Circuit from ±5 V Supply**

\[ P2 + P5 = 2524.00 + 2625.00 = 5149.00 \text{ mW} \]

**Total Power for Analog Circuit from ±12 V Supply**

\[ P1 + P3 + P4 = 1153.25 + 1208.10 + 707.40 = 3068.75 \text{ mW} \]

**Total Power for Digital Circuit from +5 V Supply**

\[ P6 + P7 + P8 = 1485.00 + 3331.80 + 8070.00 = 12886.80 \text{ mW} \]

**Total Power for the Card**

\[ P1 + P2 + P3 + P4 + P5 + P6 + P7 + P8 = 8217.75 + 12886.80 = 21104.55 \text{ mW} \]
VITA

Tamer Refaat


EDUCATION:

POSITIONS:
- September 1991 - December 1995; Teaching Assistant, Electrical Engineering Department, Faculty of Engineering, Alexandria University, Alexandria, Egypt.
- January 1996 - June 1996; Research Assistant, Physical Electronics Research Laboratory, Electrical and Computer Engineering Department, Old Dominion University, Norfolk, VA.
- July 1996 - December 1999; Research Assistant, Electrical and Computer Engineering Department, Old Dominion University, Research and Thesis at NASA Langley Research Center: Atmospheric Science Division & Opto-Electronic and Control Branch, Hampton, VA.
- January 2000 - Present; Lidar Detection System Design, Science and Engineering Services Inc. 4032 Blackburn Lane, Burtonsville, MD

EXPERIENCE: